

Working Group 1

WG1 Summary & Plan with Recommendations to the CB

- Confirm baseline layout for Low/High B sections
 - Performance of the different layout options
 - Stability/repeatability attainable in presence of microphonics, Lorenz detuning, detuned cavities, reflections due to RF distribution component imperfections
 - Difficulties with long waveguides (e.g. for RF Feedbacks)?
- Power Margins needed – identify & quantify definitively – bad/good cavities
- Klystron Modulator specs and design options – HPSPL needs, including space & integration !
- Power Coupler options – existing design & experience, overall review, requirements to get to high power – studies needed, prototyping requirements
- Integration studies, get first version of Klystron Gallery layout / Integration
- Investigate cost-cutting solutions in the RF Power and LLRF systems



List of Presentations

Modulators - Company Presentation SCANDINOVA

Klas Elmquist

(SCANDINOVA SYSTEMS AB)

Magnetron Power Sources

Amos Dexter (Lancaster U.)

Tuner design and performance

Guillaume Devanz (CEA)

Coupleurs XFEL-Spécifications Techniques

et Stratégie Industrielle

Aboud Falou (LAL)

Conditionnement HF des coupleurs TTF-3

et critères XFEL

Lucija Lukovac (LAL)

CEA Saclay Coupler Tests

Guillaume Devanz CEA)

SPL coupler options and integration requirements

Eric Montesinos (CERN)

Development paths for High average RF Power Couplers

Eric Montesinos (CERN)

Lorentz force detuning measurements on the CEA cavity

Daniel Valuch (CERN)

RF simulations

W. Hofle, Mathias Hernandez
(CERN)

+ Specialist Input – R. Rimmer, (JLAB) R. Pasquinelli (Fermilab)

Modulators - SCANDINOVA – K. Elmquist

One modulator per klystron, driving 2 cavities

LP-SPL (500 kW on cavity)

flat top: 1.8 ms

rep-rate: 2 Hz

voltage: 110 kV

droop: 5%

power: 3.2-3.4 MW (500 kW per cavity) + margin for splitting and LLRF + 50% klystron efficiency)

HP-SPL (1 MW on cavity)

flat top: <2.1 ms

rep-rate: 50 Hz

voltage: 110 kV

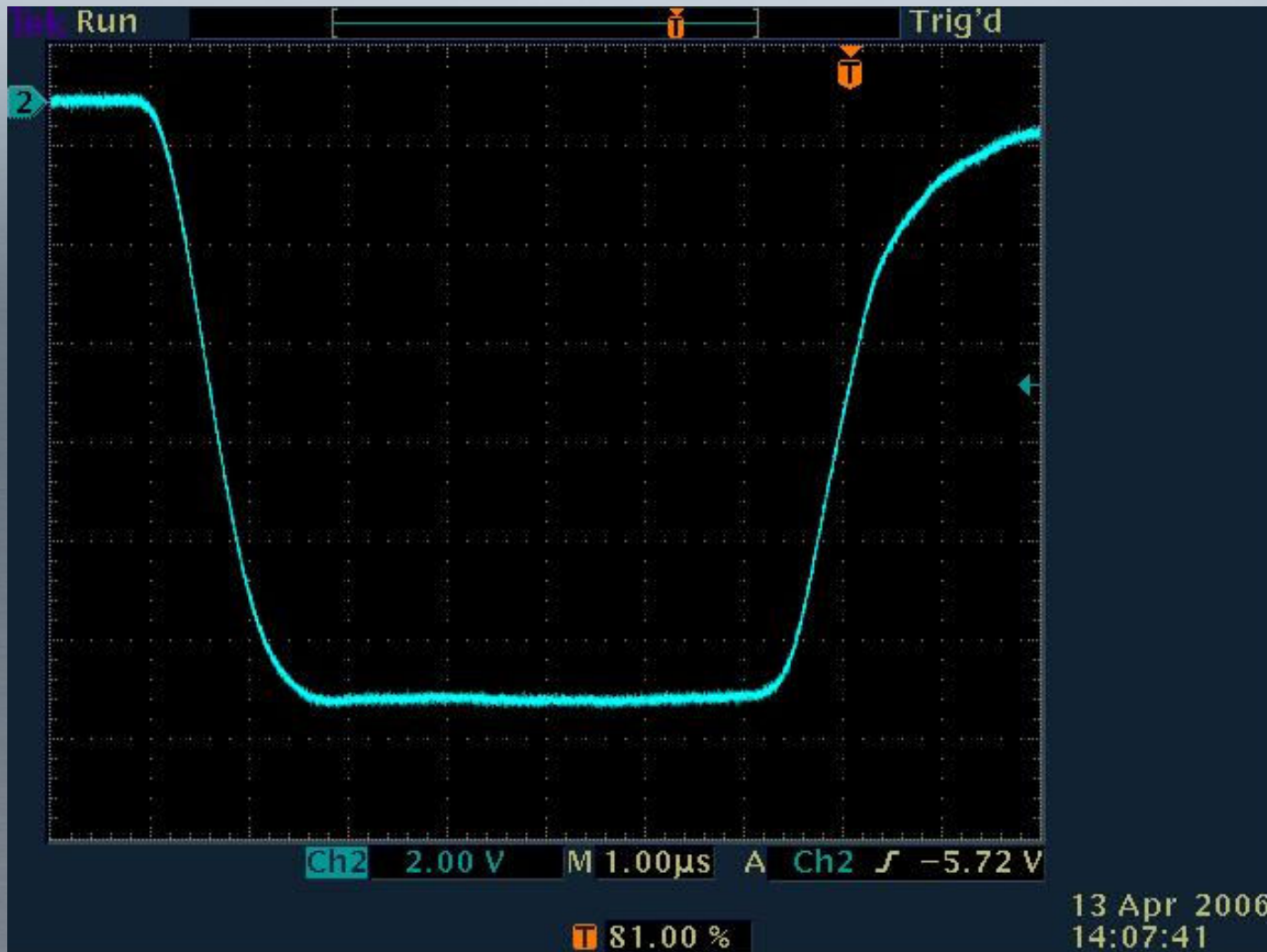
droop: 5%

power: 6.4-6.8 MW (1 MW per cavity + margin for splitting and LLRF + 50% klystron efficiency)

K2-SYSTEM FOR PSI 351kV / 416A *ScandiNova*

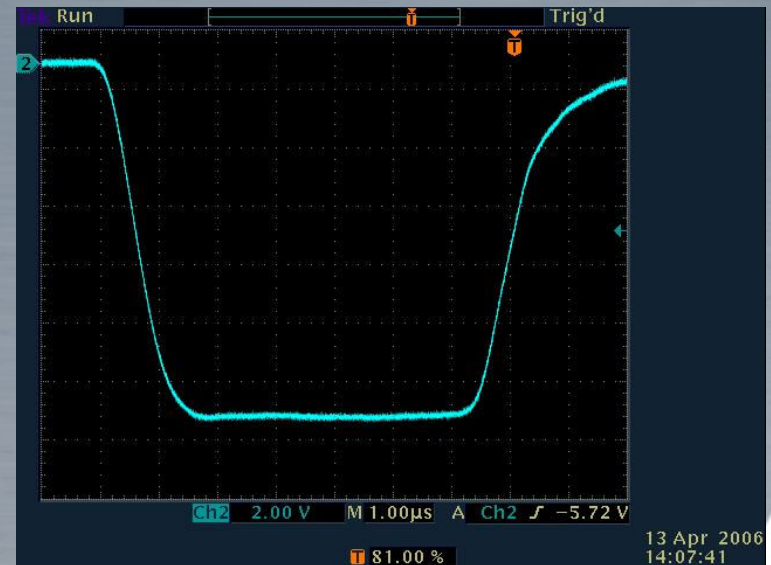


K1-SYSTEM KLYSTRON PULSE 140kV *ScandiNova*



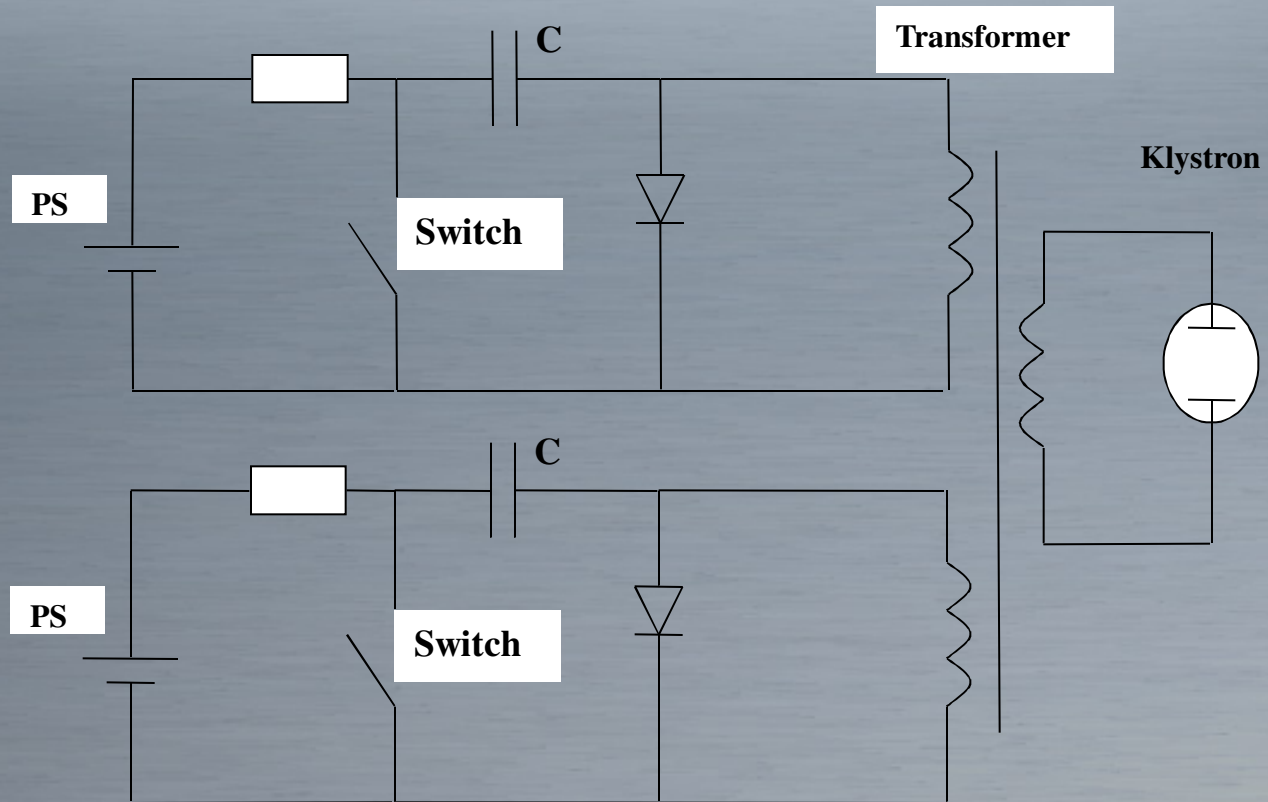
ACHIEVED LEVELS

Parameter	Value
Peak Power	147 MW
Average Power	106 kW
Pulse Voltage	507 kV
Pulse Current	4000 A
Pulse length	25 us
Pulse Repetition Rate	1000 Hz
Rise time	286 kV/us
Fall time	280 kV/us
Pulse flatness	$\pm 0.05\%$
Pulse to Pulse stability	$\pm 0.002\%$

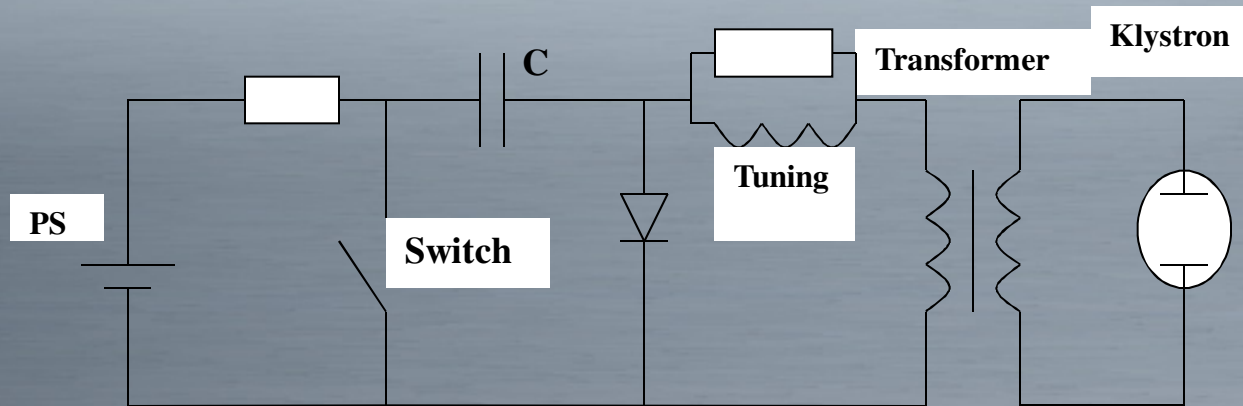


Basic schematic of the Scandinoa modulator

N = number of primary circuits
 R = Klystron Resistance
 N_T = Transformer ratio (Has to be compensated for with N)

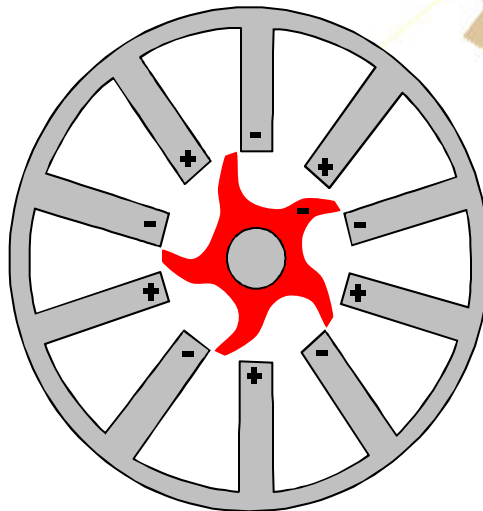
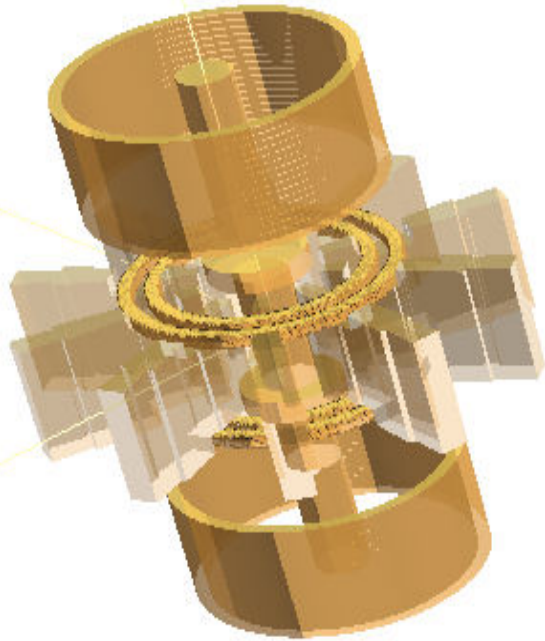


Tuning



R_t = Tuning resistance
L_t = Tuning inductance

Amos Dexter, Imran Tahir, Bob Rimmer and Richard Carter



Single magnetrons 2.856 GHz, 5 MW, 3 μ s pulse, 200 Hz repetition are used to power linacs for medical and security applications.

Multiple magnetrons have been considered for high energy normal conducting linacs but the injection power needed for an unstabilised magnetron made it uncompetitive with a Klystron.

Overett, T.; Bowles, E.; Remsen, D. B.; Smith, R. E., III; Thomas, G. E. “Phase Locked Magnetrons as Accelerator RF Sources” *PAC* 1987

Benford J., Sze H., Woo W., Smith R., and Harteneck B., “Phase locking of relativistic magnetrons” *Phys. Rev.Lett.*, vol. 62, no. 4, pp. 969, 1989.

Treado T. A., Hansen T. A., and Jenkins D.J. “Power-combining and injection locking magnetrons for accelerator applications,” *Proc IEEE Particle Accelerator Conf.*, San Francisco, CA 1991.

Chen, S. C.; Bekefi, G.; Temkin, R. J. “Injection Locking of a Long-Pulse Relativistic Magnetron” *PAC* 1991

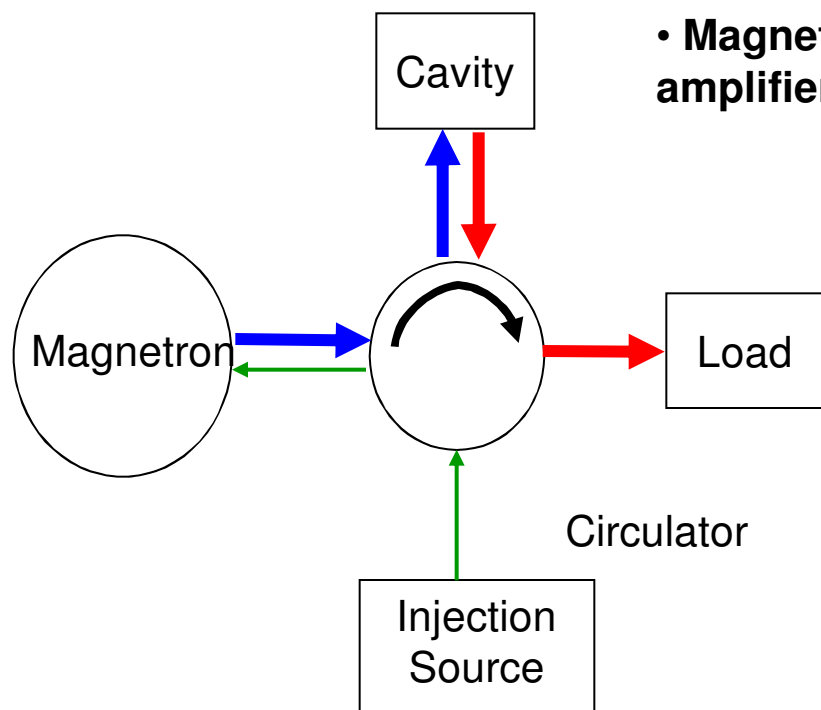
Treado, T. A.; Brown, P. D.; Hansen, T. A.; Aiguier, D. J. “Phase locking of two long-pulse, high-power magnetrons” , *IEEE Trans. Plasma Science*, vol 22, p616-625, 1994

Treado, Todd A.; Brown, Paul D., Aiguier, Darrell “New experimental results at long pulse and high repetition rate, from Varian's phase-locked magnetron array program” *Proceedings Intense Microwave Pulses*, SPIE vol. 1872, July 1993



Courtesy of e2v

- Linacs require accurate phase control
- Phase control requires an amplifier
- Magnetrons can be operated as reflection amplifiers



Compared to Klystrons, in general Magnetrons

- are smaller
- more efficient
- can use permanent magnets (at 704 MHz)
- utilise lower d.c. voltage but higher current
- are easier to manufacture

Consequently they are much cheaper to purchase and operate

J. Kline “The magnetron as a negative-resistance amplifier,”
IRE Transactions on Electron Devices, vol. ED-8, Nov 1961

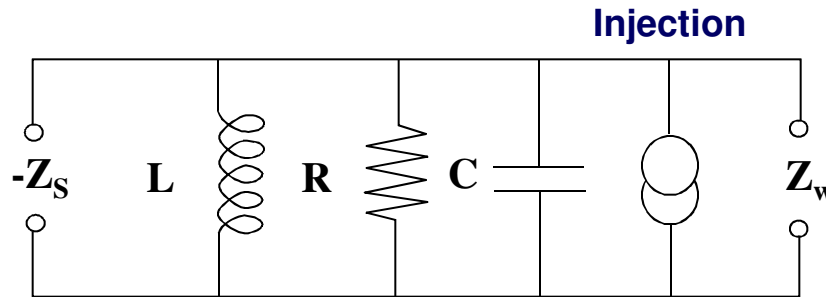
H.L. Thal and R.G. Lock, “Locking of magnetrons by an injected r.f. signal”,
IEEE Trans. MTT, vol. 13, 1965

J.C. Slater "The Phasing of Magnetrons" MIT Technical Report 35, 1947

Shien Chi Chen "Growth and frequency Pushing effects in Relativistic Magnetron Phase – Locking", IEEE Trans. on Plasma Science Vol. 18 No 3. June 1990.

The basic circuit model for the phased locked magnetron is the same as for a cavity

Negative impedance to represent magnetron spokes excitation of the anode. Includes static pushing effects.



Load impedance includes pulling effects.

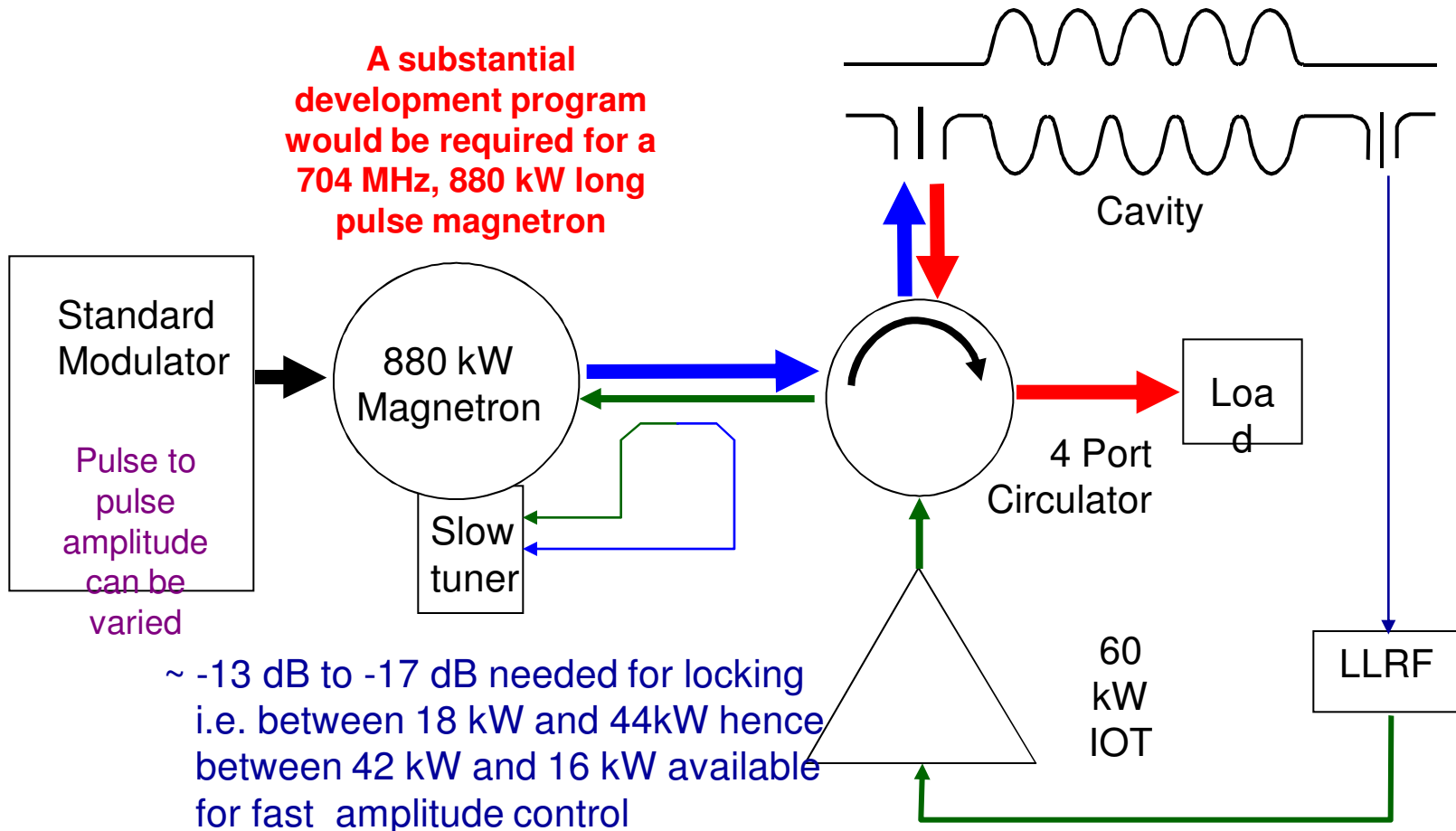
$$\ddot{V} - \frac{\omega_o}{Q_w} \left(\frac{Z_w}{Z_s} - \frac{Z_w}{R} - 1 \right) \dot{V} + \omega_o^2 V = -j \frac{\omega_o \omega_i}{Q_w} V_{inj} \exp(-j\omega_i t)$$

To get Adler's equation set $V(t) = A(t) \exp\{-j(\omega t + \psi(t))\}$

to give

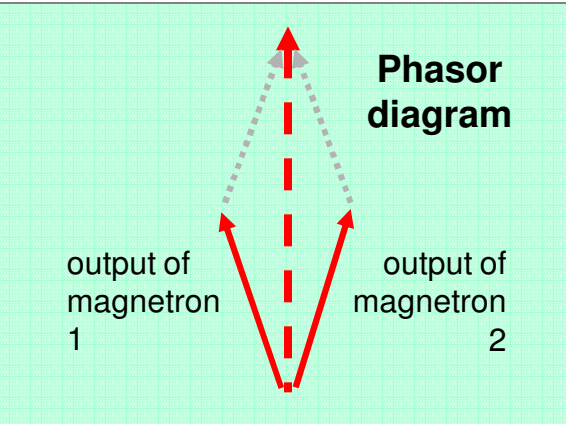
$$\frac{d\psi}{dt} = -\frac{V_{inj}}{V_{RF}} \frac{\omega_o}{2Q_L} \sin\psi + \omega_o - \omega_i$$

Permits fast phase control but only slow, full range amplitude control

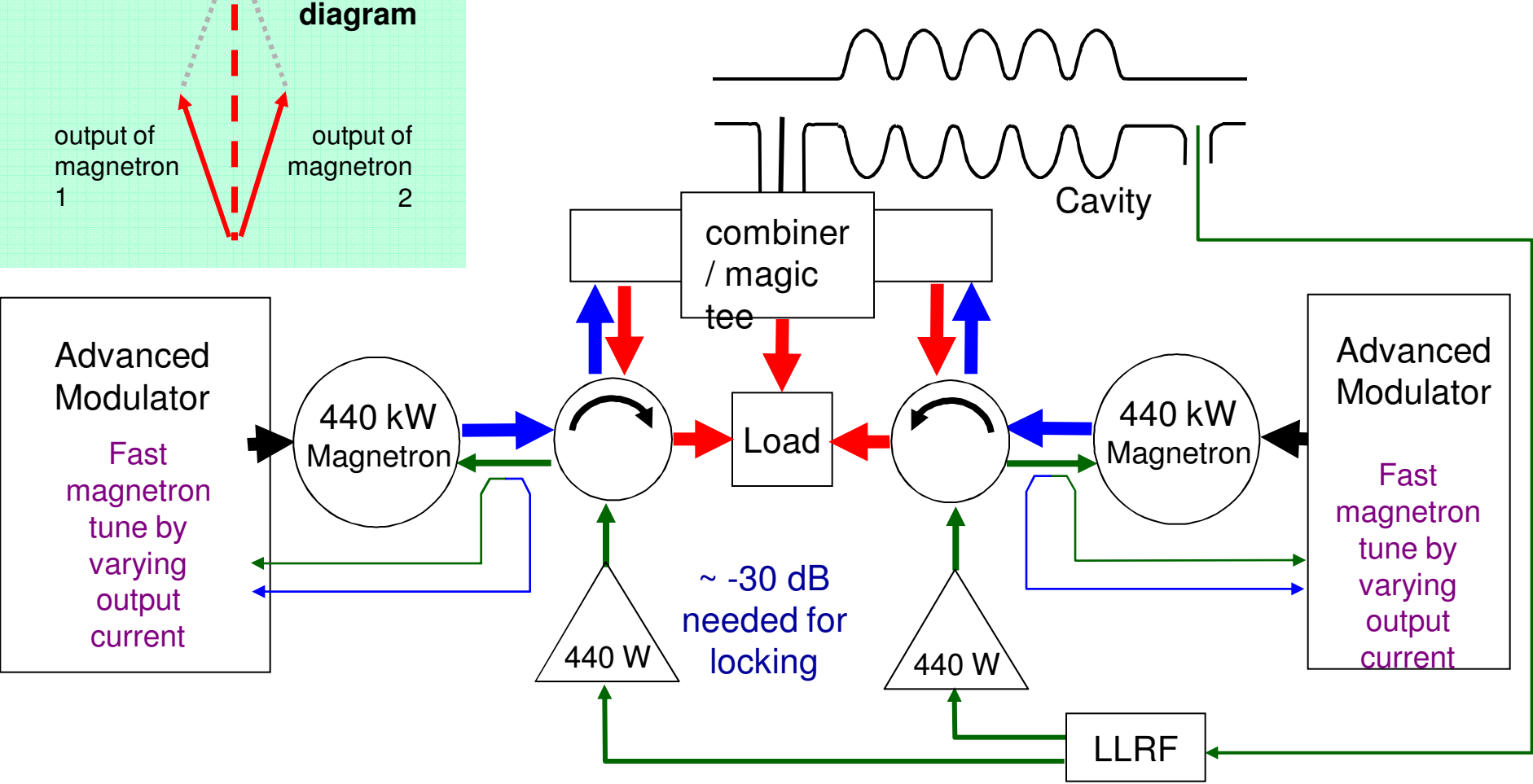


Could fill cavity with IOT then pulse magnetron when beam arrives

Layout using two magnetrons per cavity

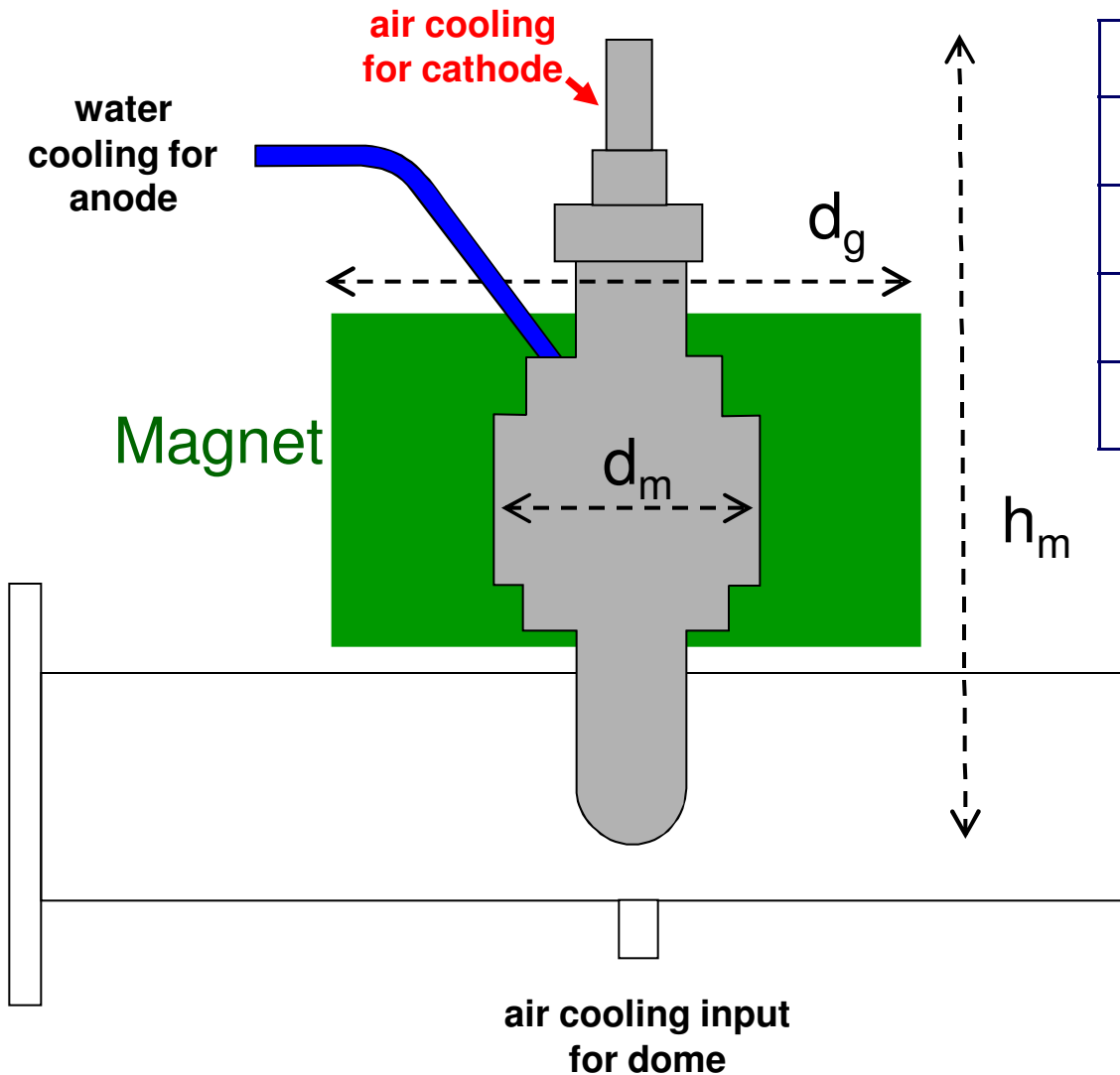


Permits fast full range phase and amplitude control



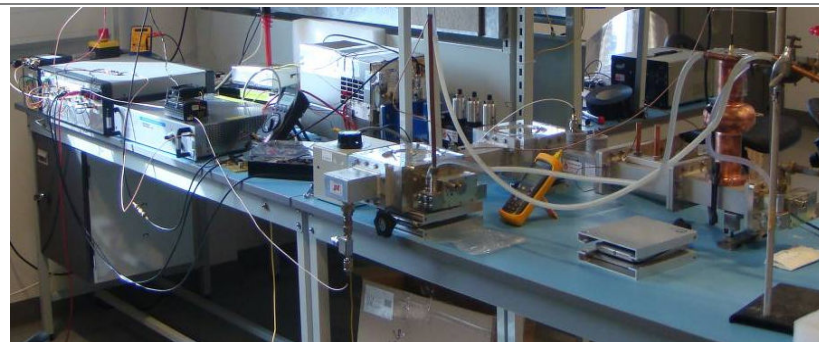
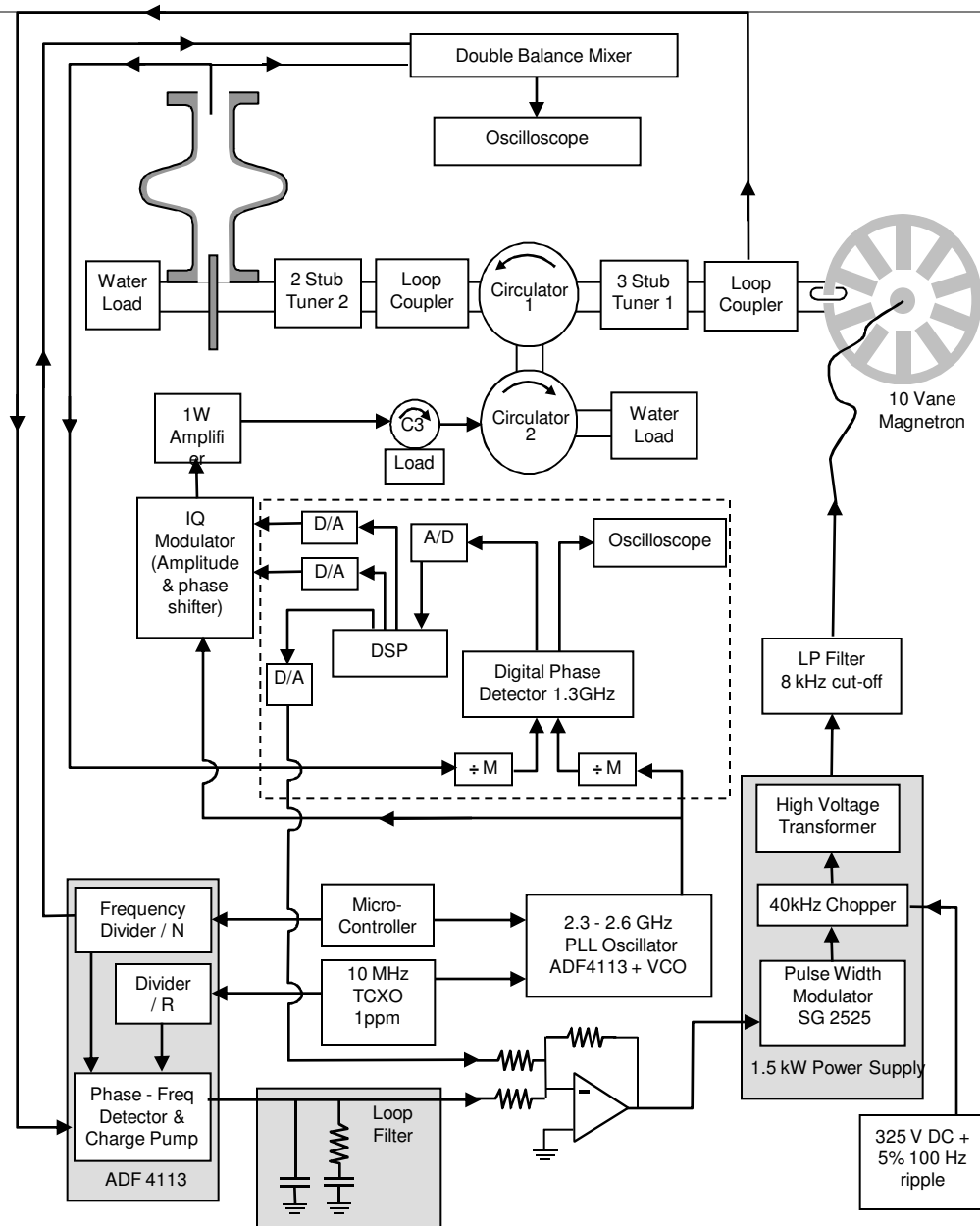
440 kW Magnetron design is less demanding than 880 kW design reducing cost per kW, and increasing lifetime and reliability.

Magnetron Size



	915 MHz	704 MHz
d_g	325 mm	~ 425 mm
d_m	125 mm	~ 165 mm
h_m	500 mm	~ 650 mm
€ tube	€ 8000	?

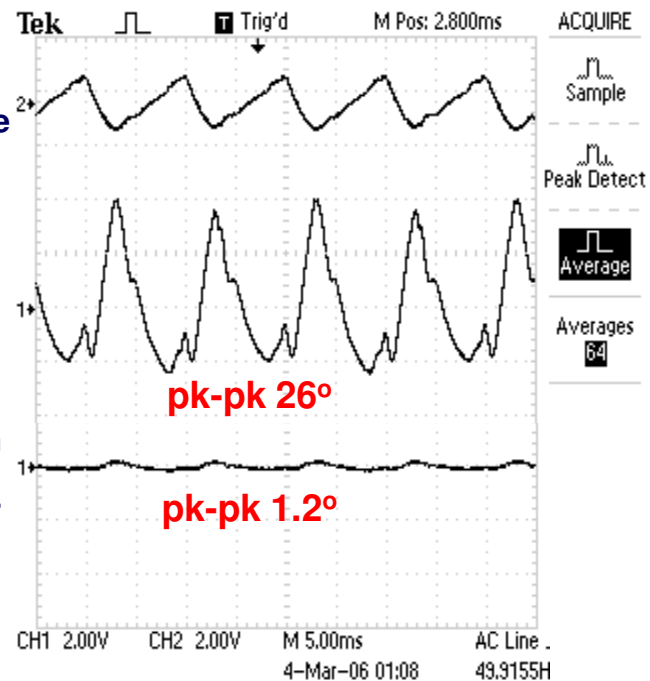
If magnetron design is similar to industrial design with similar tolerances and can be made on same production line then cost may not be much more



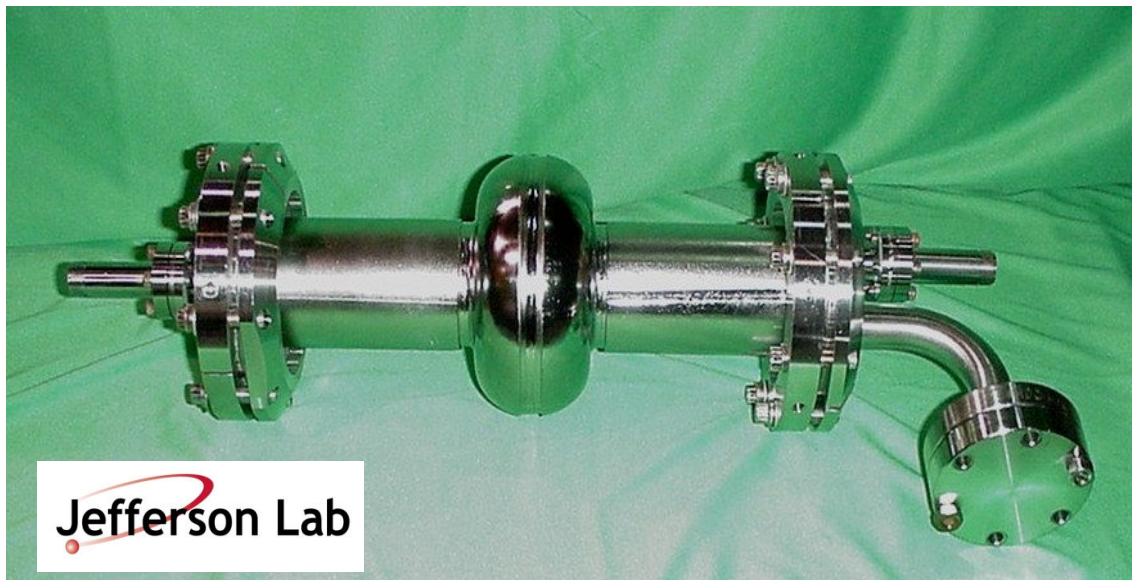
Power supply ripple

Magnetron phase no LLRF

Magnetron phase with LLRF



- Commission the development of a 704MHz Magnetron (440kW)
- Procure standard modulator
- Set up test station with IOT as drive amplifier
- Understand locking characteristics of new magnetron
- Commission advanced modulator with in-pulse current control
- Establish minimum locking power
- Establish two magnetron test stand
- Develop LLRF for simultaneous phase and amplitude control



Demonstration of CW 2.45 GHz magnetron driving a specially manufactured superconducting cavity at JLab due later this month should stimulate more interest.

Tuner Design & Performance

G. Devanz (CEA)

Tuning system requirements

Can be corrected with room temperature tuning using plastic deformation:

- Fabrication tolerances
- Main cavity treatments :
 - 800 °C heat treatment against Q disease,
 - First heavy chemical treatment (150 to 200 μm)
- Field imbalance between cells

Has to be corrected with the cold tuner:

- The remaining error of the room temperature tuning
- The effect of the last chemical treatments
- The differential shrinkage of materials of the cavity, He vessel and tuner
- He Pressure, Lorentz detuning,

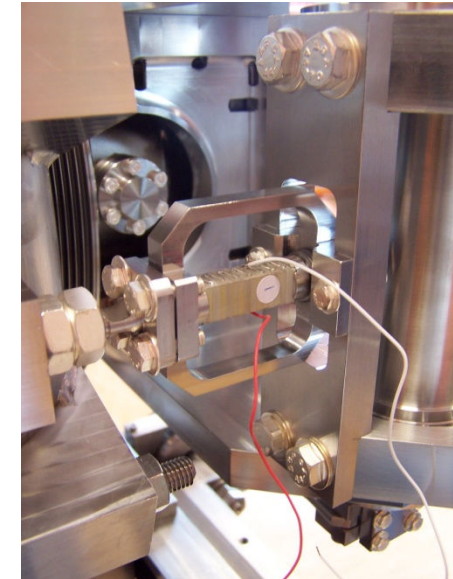
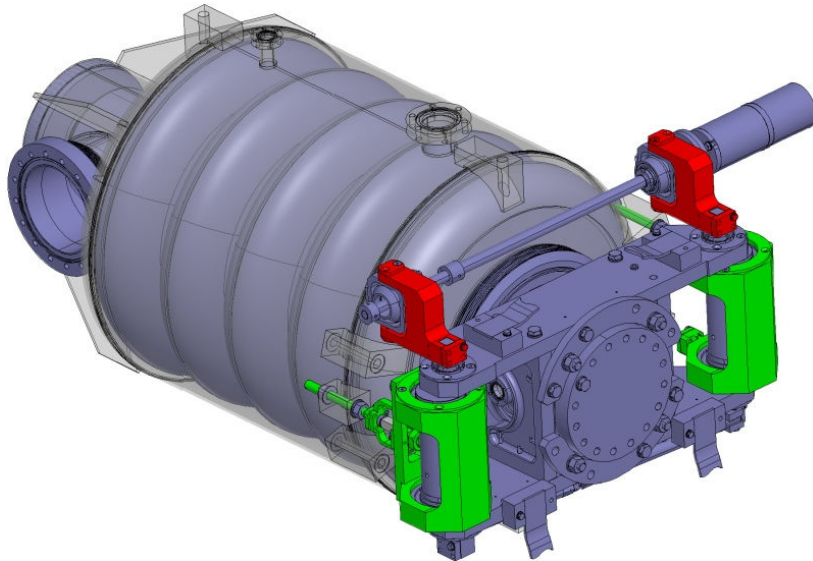
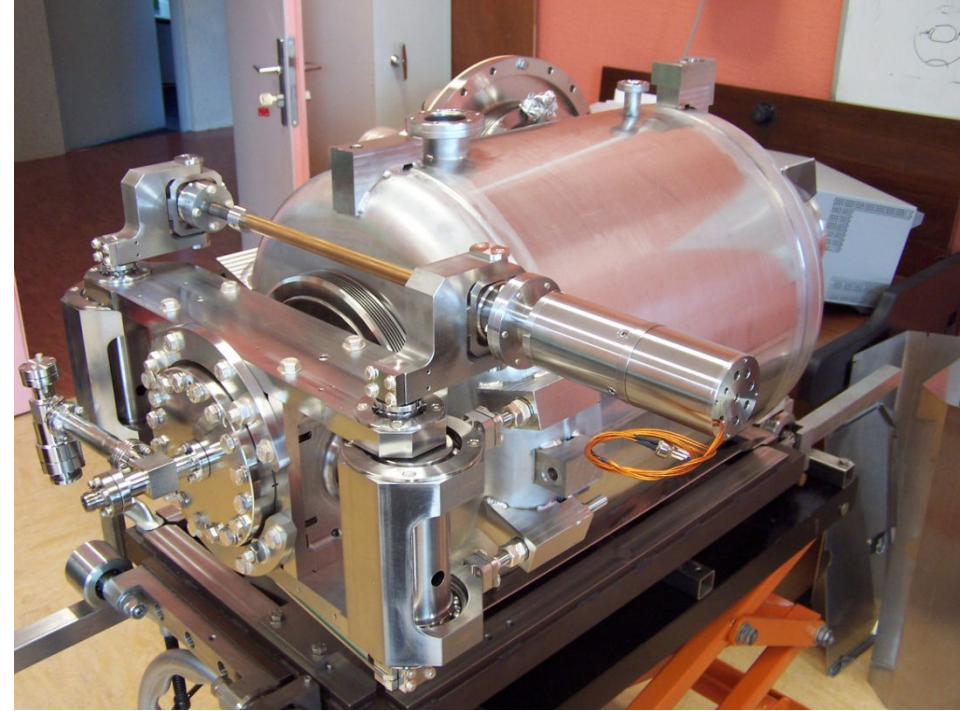
However:

- Last points (diff. Shrinkage) can be taken into account for series cavities after the full test of the first prototype

RANGE? (also operation/commissioning of the accelerator)

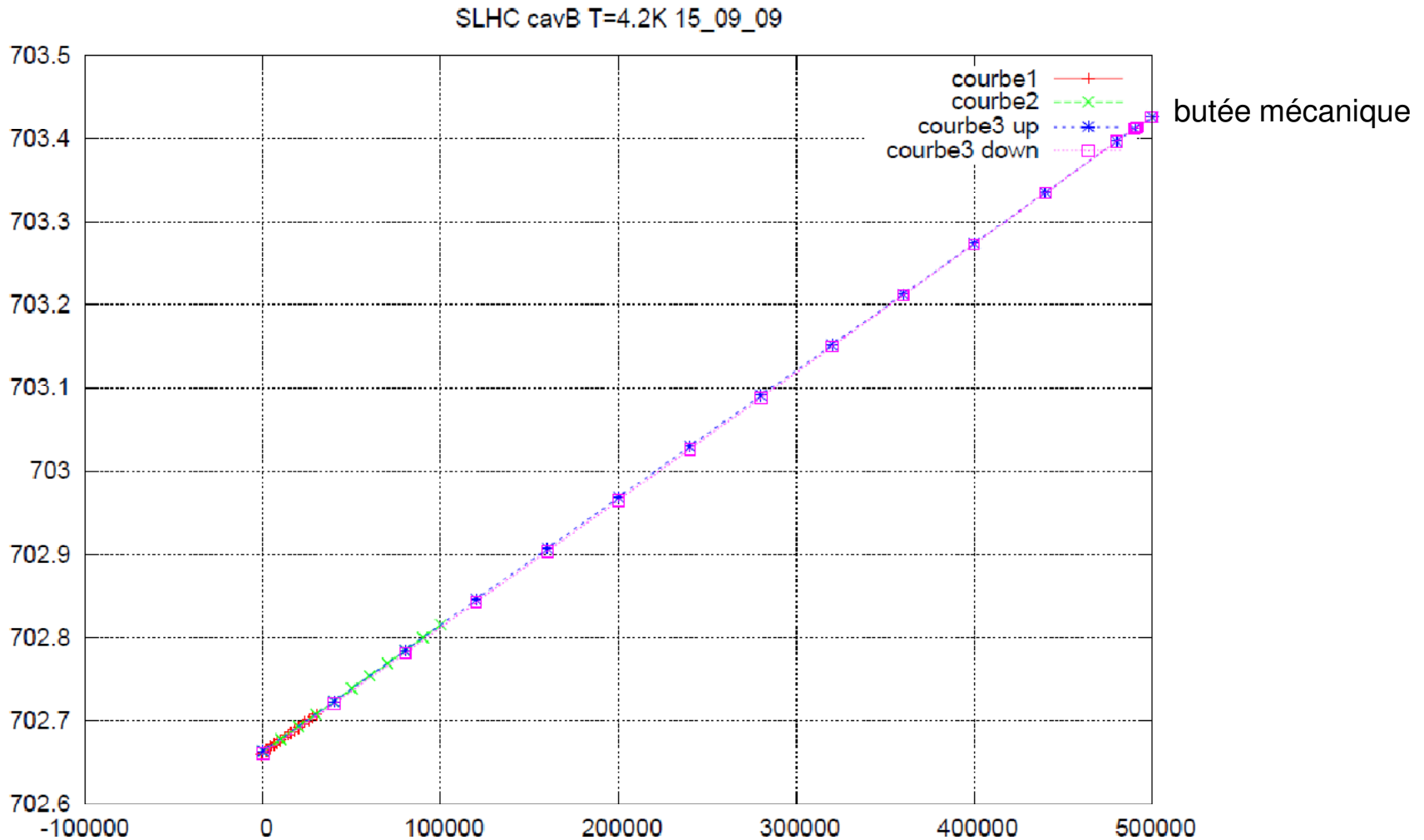
Saclay piezo tuner for 700MHz cavities

- Slow tuner with symmetric action
- Excentric/lever arm proven Saclay design
- Planetary gear box (3 stages)
- Single NOLIAC 30mm piezo actuator
- Stiffness measured on the tuner
pneumatic jack = 35 kN/mm
- Initially developed for the beta=0.5 5-cell cavity

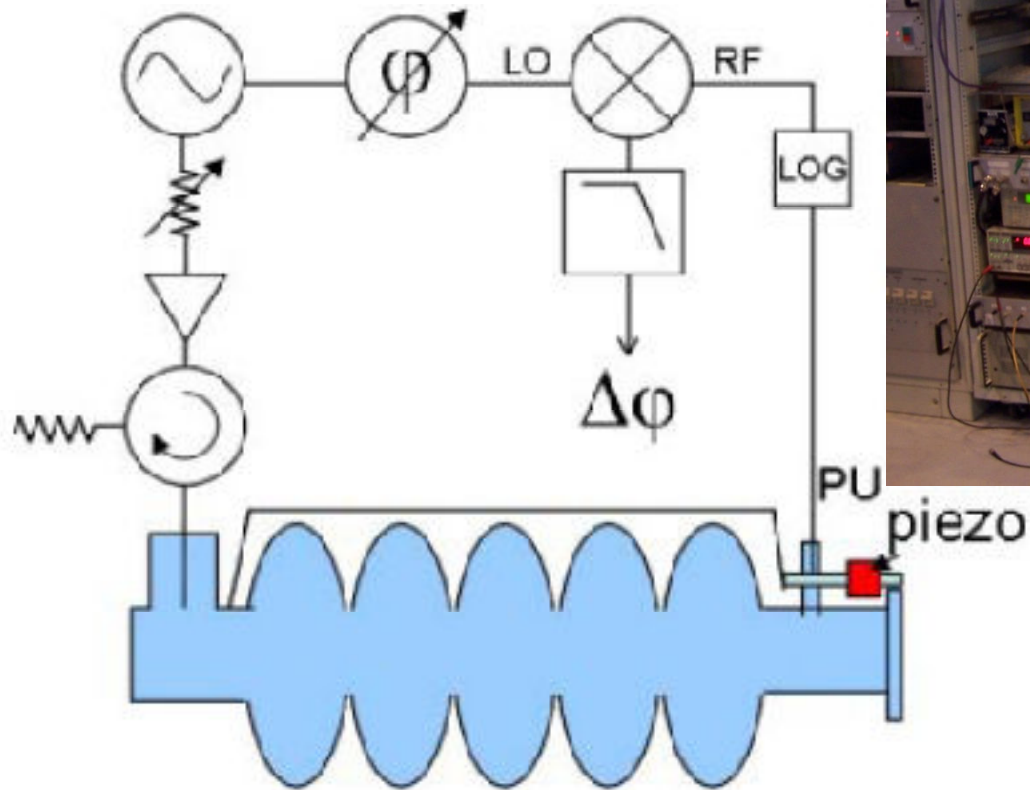


Beta 0.5 cavity tuning

- 4.5 K, amplitude = +760kHz corresponding to 2.5 mm -> would be +400 kHz on SPL beta=1 cavity
- Mechanical hysteresis measurements will be done at 2 K

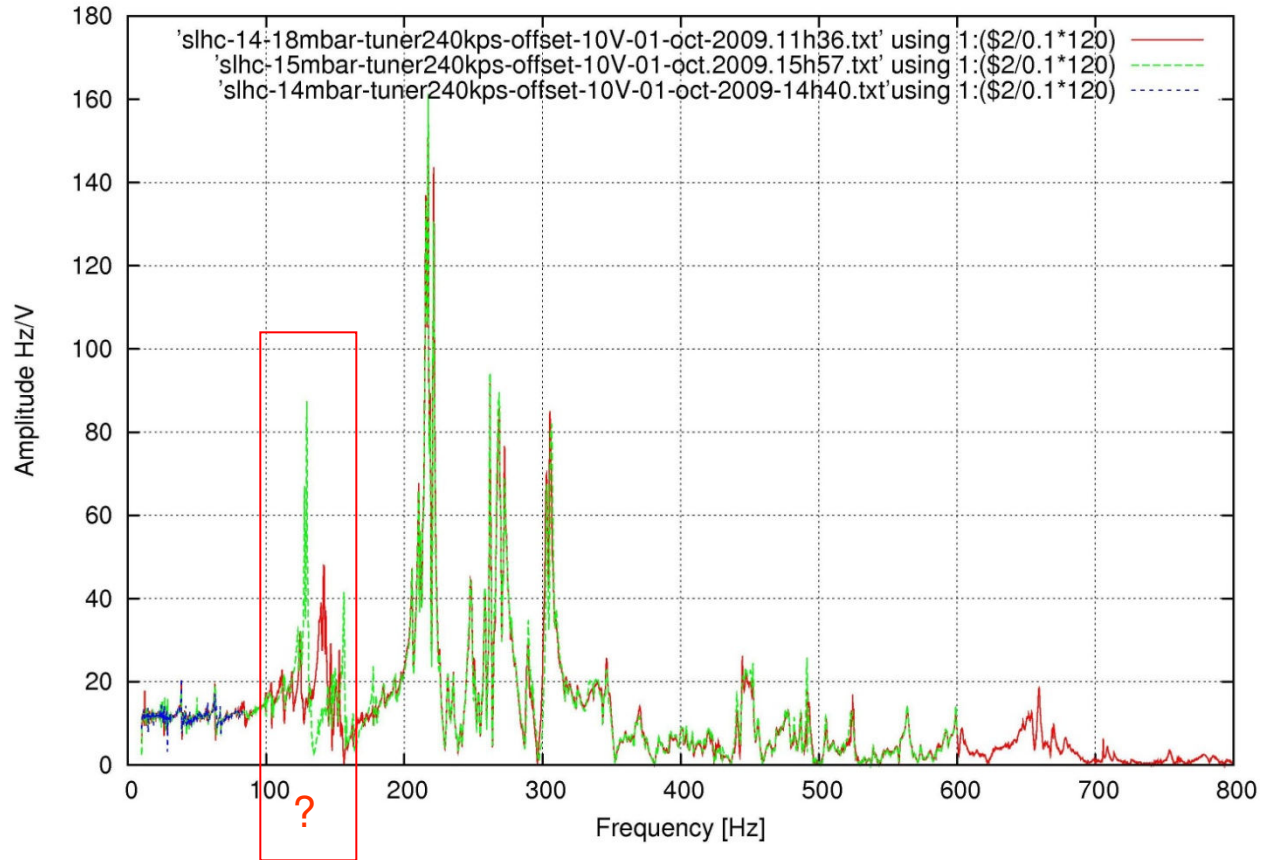


Transfer function measurements



Transfer function measurements

SLHC cavB piezo to frequency transfer function



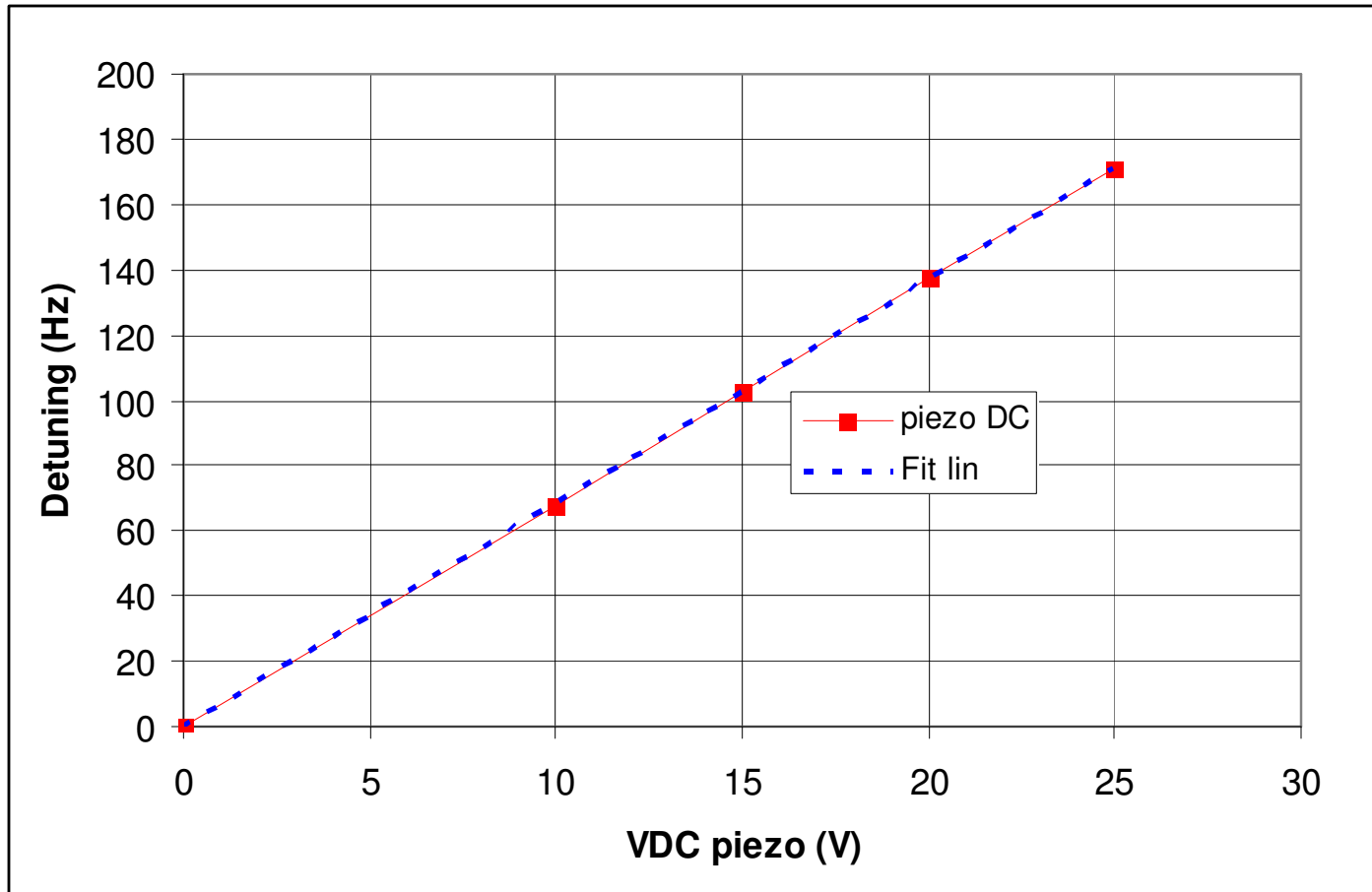
Phase demodulation measurements at 1.8K in Cryholab

TF piezo drive voltage -> cavity detuning can be used to identify the mechanical modes of the system, especially modes generating most detuning (220 Hz)

Reproducible measurements except in the 100-160 Hz range (why?)

$F_{cav} = 703$ MHz, far from tuner neutral point

Piezo detuning (DC)



measured at 1.8 K (main tuner parts at 20 K)

piezo 44V for 1 μm elongation of the cavity ($\sim 2 \mu\text{m}$ for the piezo actuator)

Maximum detuning measured at 150V DC = +1 kHz

Conclusion

- Piezo tuner is working as expected
- Characterization of the cavity is going on
- Lorentz Force Detuning compensation not yet tested, will be done with the fixed and modified HPVS, with long pulses 2ms, 50 Hz
- Preliminary compensation tests with 2 ms, 5 Hz are foreseen in the upcoming weeks
- The CERN crate is working now as an fast IQ acquisition system, will be used as the piezo controller, and ultimately an adaptive feed-forward for LFD compensation could be implemented.

- Coupleurs XFEL - A. Falou (LAL)
- Conditionnement Coupleurs TTF-3 - L. Lukovac (LAL)
- CEA Coupler Tests – G. Devanz (CEA)
- SPL Coupler Options Integration - E. Montesinos (CERN)
- Development of High av. power Couplers - E. Montesinos (CERN)

SPL 3rd Collaboration Meeting

(CERN/ from 11 to 13 November 2009)

About Falou (LAL-Orsay)

XFEL Power Couplers 1.3GHz

Technical Specification & Industrial Strategy

LAL contribution to XFEL linac at DESY



SLHC

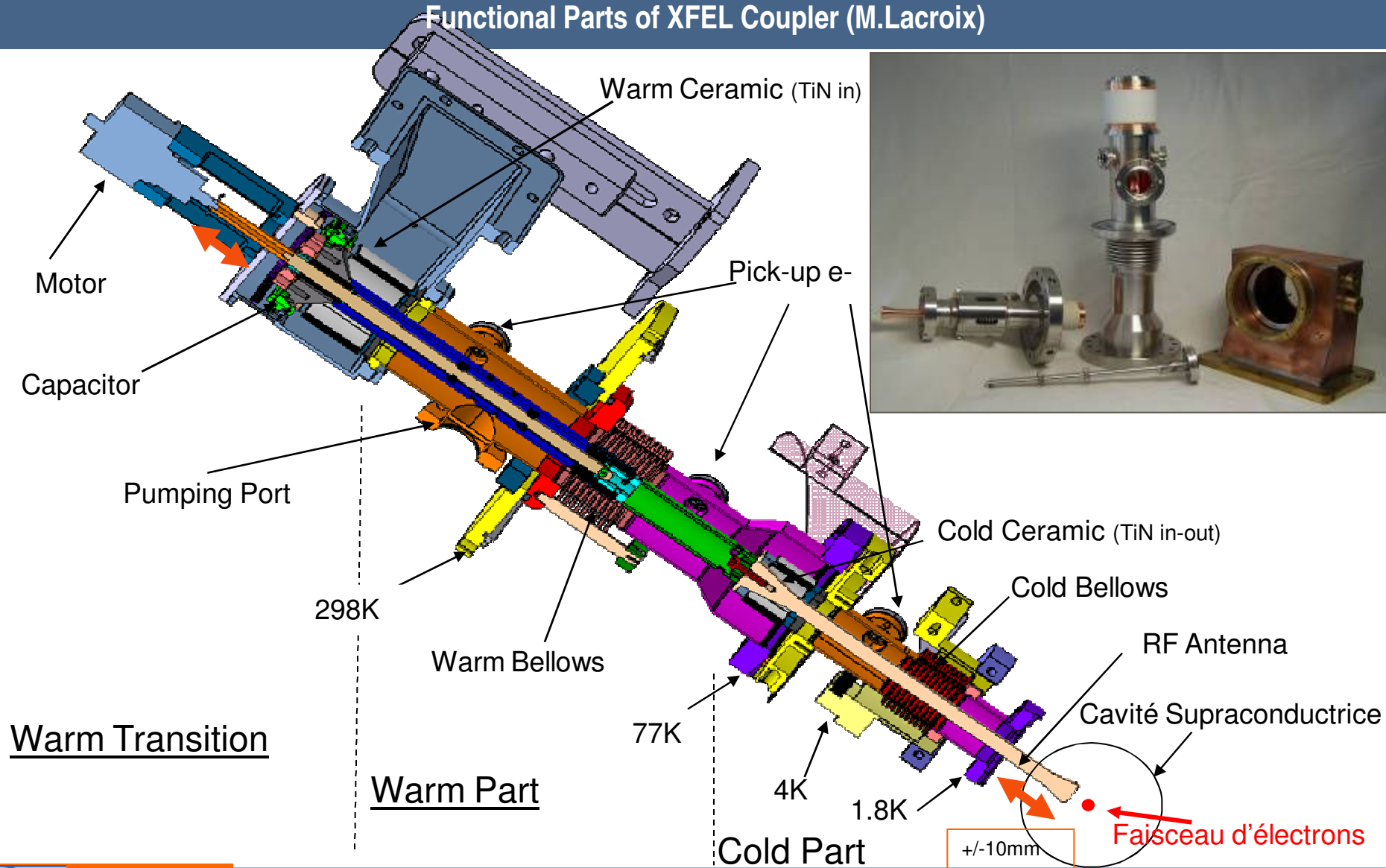


SOMMARY

- Power Couplers main components & technical performance
- Interfaces with cryomodule & string cavities
- Industrial studies & coupler prototypes
- RF contact evaluation
- Market Strategy for mass production (Technical Specifications)
- Manufacturing Sequence & Transport/Storage logistic
- Time schedule 2009/2012

XFEL RF Couplers/ from R&D to Mass Production

Functional Parts of XFEL Coupler (M.Lacroix)



XFEL RF Couplers/ from R&D to Mass Production

Major non conformities (TTF-3 Inspections)

- SS welding performance (full penetration, roughness & seam flatness at RF side).
- Copper/ceramic brazing (tensile resistance, tightness, metallic projections).
- TiN & Cu surface coating (matrix adhesion, thickness control, roughness, boundary lines).
- Final 'welding' assembly (alignment of in/out conductors, penetration, metallic projections).
- Cleaning procedures, difficult access to residual particles.
- Wave Guide Boxes soldering (lack or excess of metal, acid discoloration).
- RF contact between Wave Guide Box & coupler flanges (misalignment, sparks).
- Translation mechanism of RF antenna (alignment, mechanical constraints).
- Bolting dysfunction under UHV environment (gripping).

- . **Brazing final assembly, 2 proto Feb 2008 from Toshiba**
 - Cleaning non conformity, couplers complete dismounting at LAL, fully cleaning up, drying and remounting.
 - Automatic RF processing failed, many vacuum interlocks. RF manual processing was successful.
 - Possible failure reasons: High T°C TiN cycles, Hollow antenna.
- . **EB weld final assembly, 2 proto March 2008 from Accel**
 - Cleaning non conformity, back to the company and fully cleaned up.
 - Automatic RF processing successful, few interlocks.
 - RF contact failed during sweeps (capacitor springs assembly).

- . **EB weld final assembly, 2 from Thales (Tin & Cr2O3)**
 - Automatic RF processing successful, few interlocks.
 - RF contact identical to TTF-3 design.
- . **EB weld final assembly, many TTF-3 couplers from CPI**
 - Automatic RF processing successful, few interlocks.
 - Engineering non conformance during visual inspections.
 - Couplers under operation at FLASH experiment.

XFEL RF Couplers/ from R&D to Mass Production

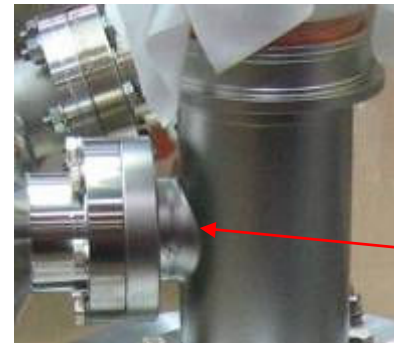
Industrial Studies/ Accepted & rejected proposals {manufacturing techniques}

Single Block Machining,
Non optimized cost



Forming by Deep drawing, recommended

Saddle weld, not recommended



Pull out + circular weld
Smooth RF surface

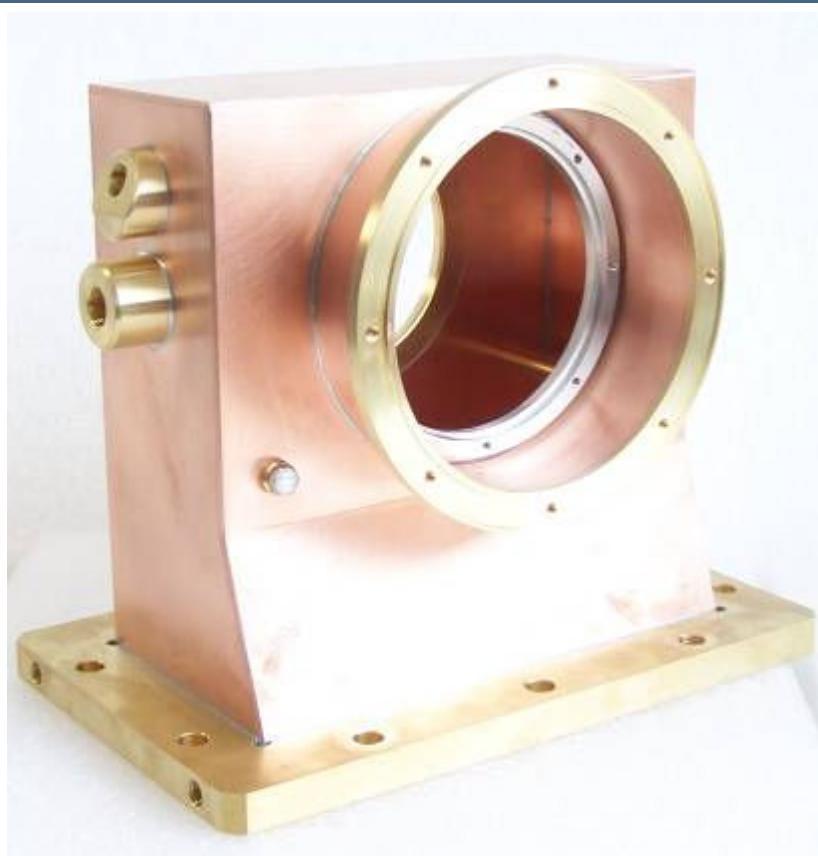
Final brazed assembly, not accepted to prevent TiN coating



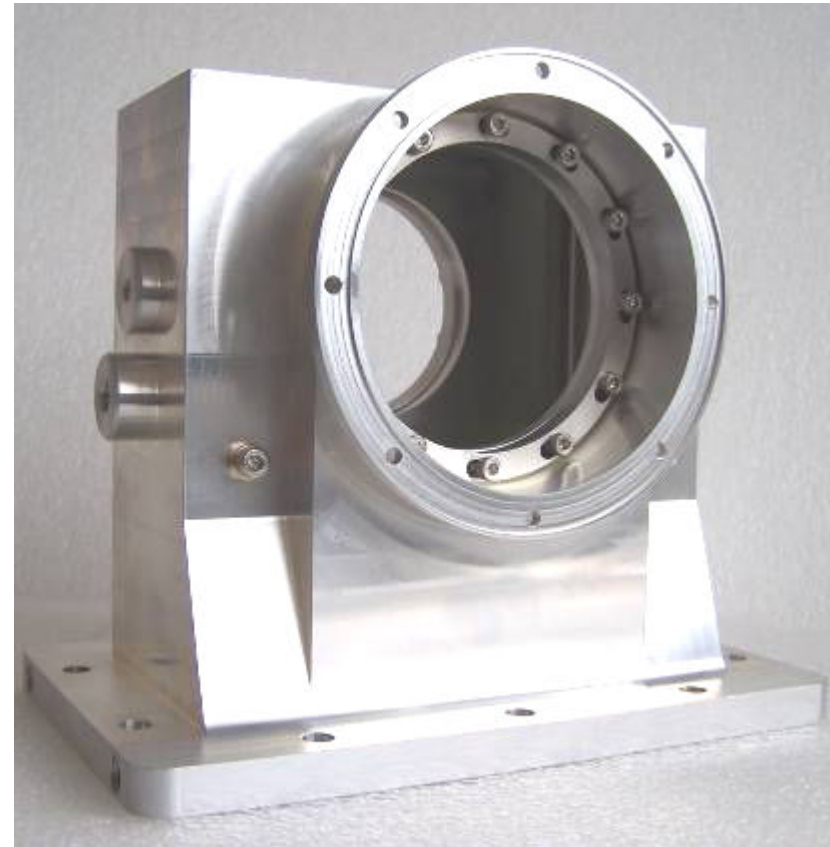
Final EB or TIG weld,
recommended.

XFEL RF Couplers/ from R&D to Mass Production

Industrial Studies/ Accepted & rejected proposals {Wave Guide Box}



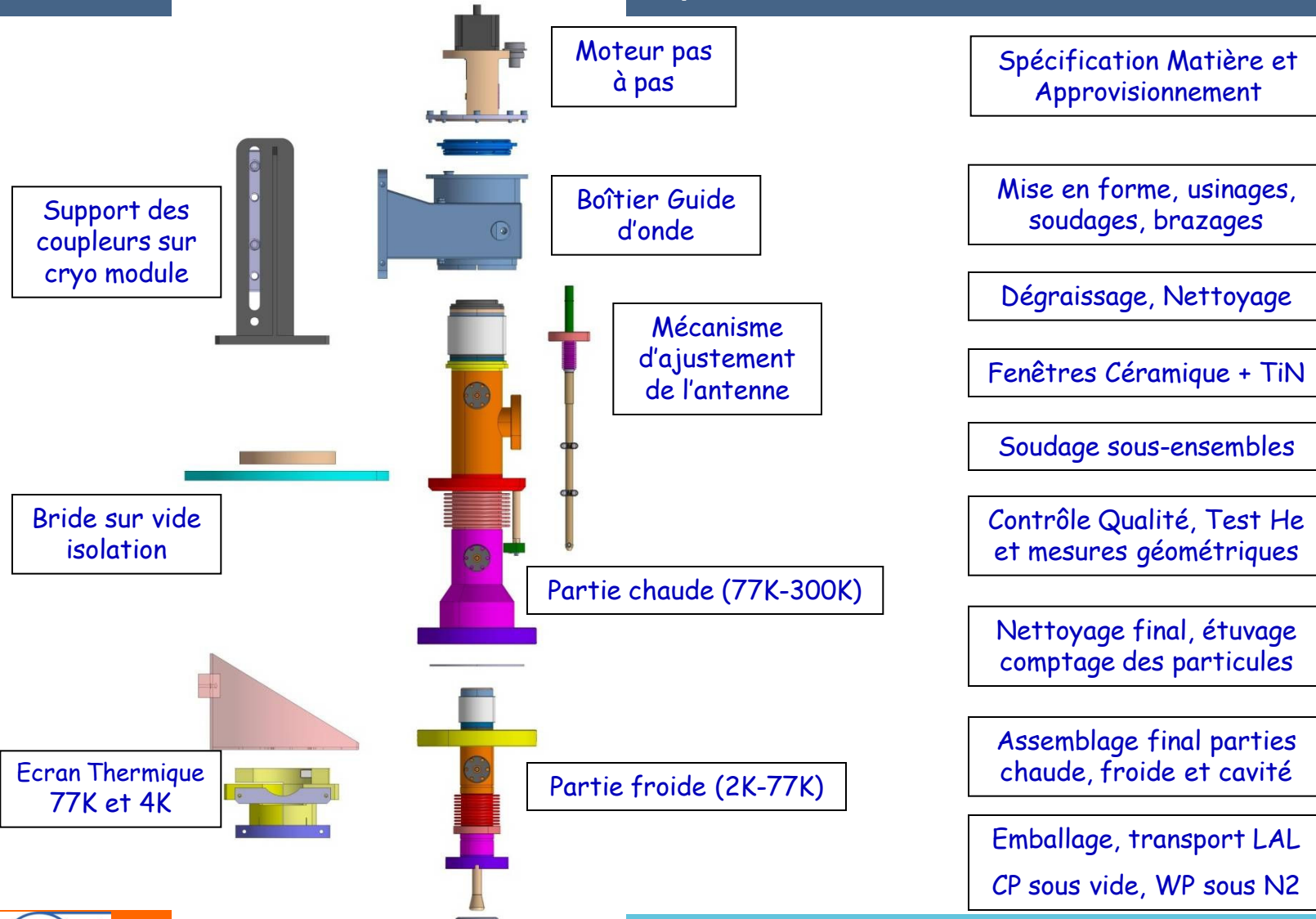
Boîtier guide d'ondes: la conception d'origine TTF-3 est un assemblage brasé de pièces cuivre, laiton et acier inoxydable. La membrane Cu donne la flexibilité pour le contact RF.



Boîtier guide d'ondes: Usinage sur CN d'un bloc massif d'aluminium exempt de soudures et brasures. Variante possible pour la production de série si le contact RF ne nécessite pas de flexibilité.

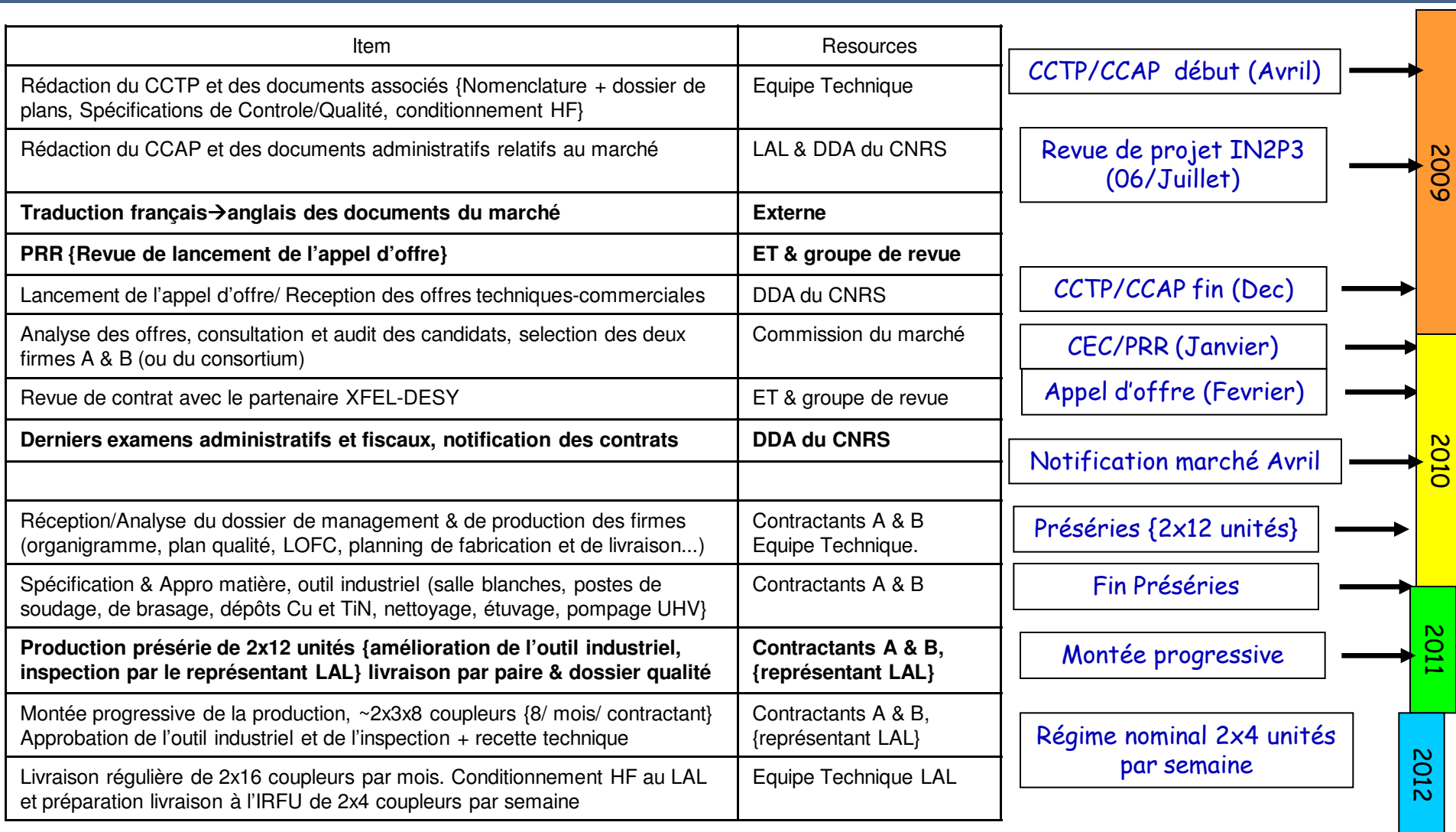
XFEL RF Couplers/ from R&D to Mass Production

Séquences de Fabrication



XFEL RF Couplers/ from R&D to Mass Production

Planning 2009-2012



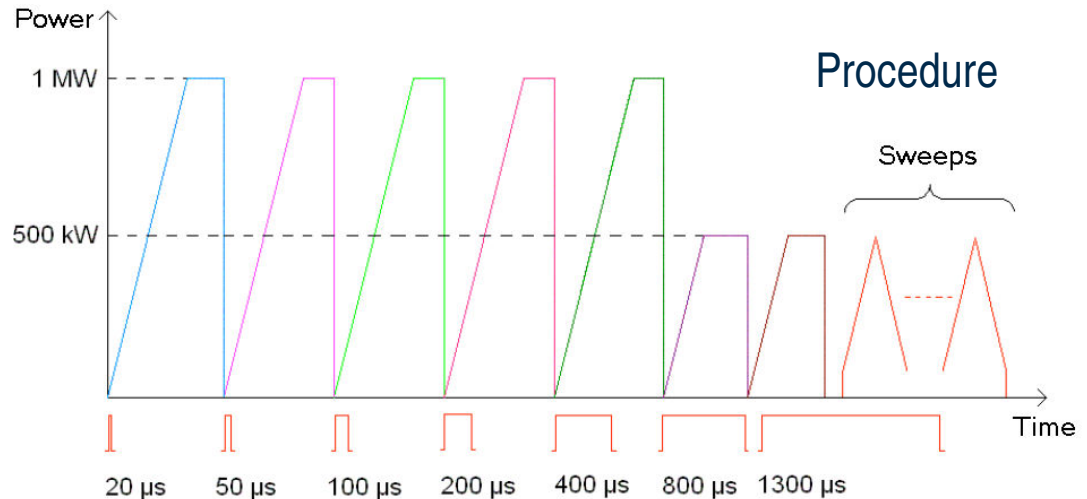
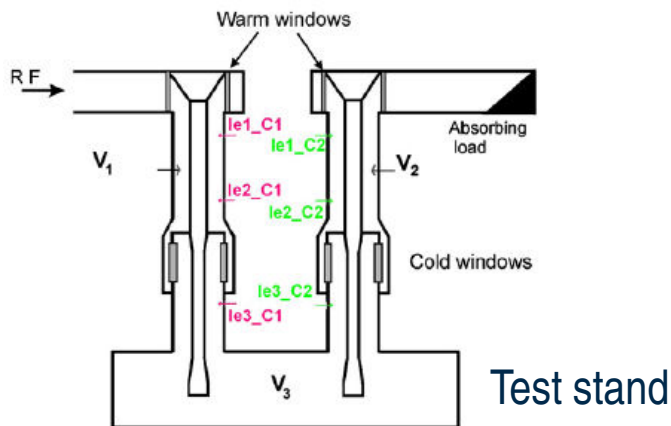
3rd SPL Collaboration Meeting

(CERN, 12 November 2009)

Lucija Lukovac (LAL)

RF Conditioning of TTF3 Input Power Couplers & Acceptance Criteria for XFEL

Warm test stand : travelling wave mode @ LAL



Control parameters

Vacuum	1st threshold (↓ 0.1 dB)	$2 \cdot 10^{-7}$ mbar
	2nd threshold (↓ 0.4 dB)	$4 \cdot 10^{-7}$ mbar
	IL	10^{-6} mbar
e- current IL		5 mA
Light IL		1 lux
Ceramic temperature IL		85° C
WG arc IL		If any
Repetition rate		2 Hz
Control loop duration ↑ 0.1 dB		30 s

Cryomodule - reconditioning : standing wave mode @ DESY

Off resonance = Warm test stand

On resonance 20 μs → 200 μs Pmax = 1 MW

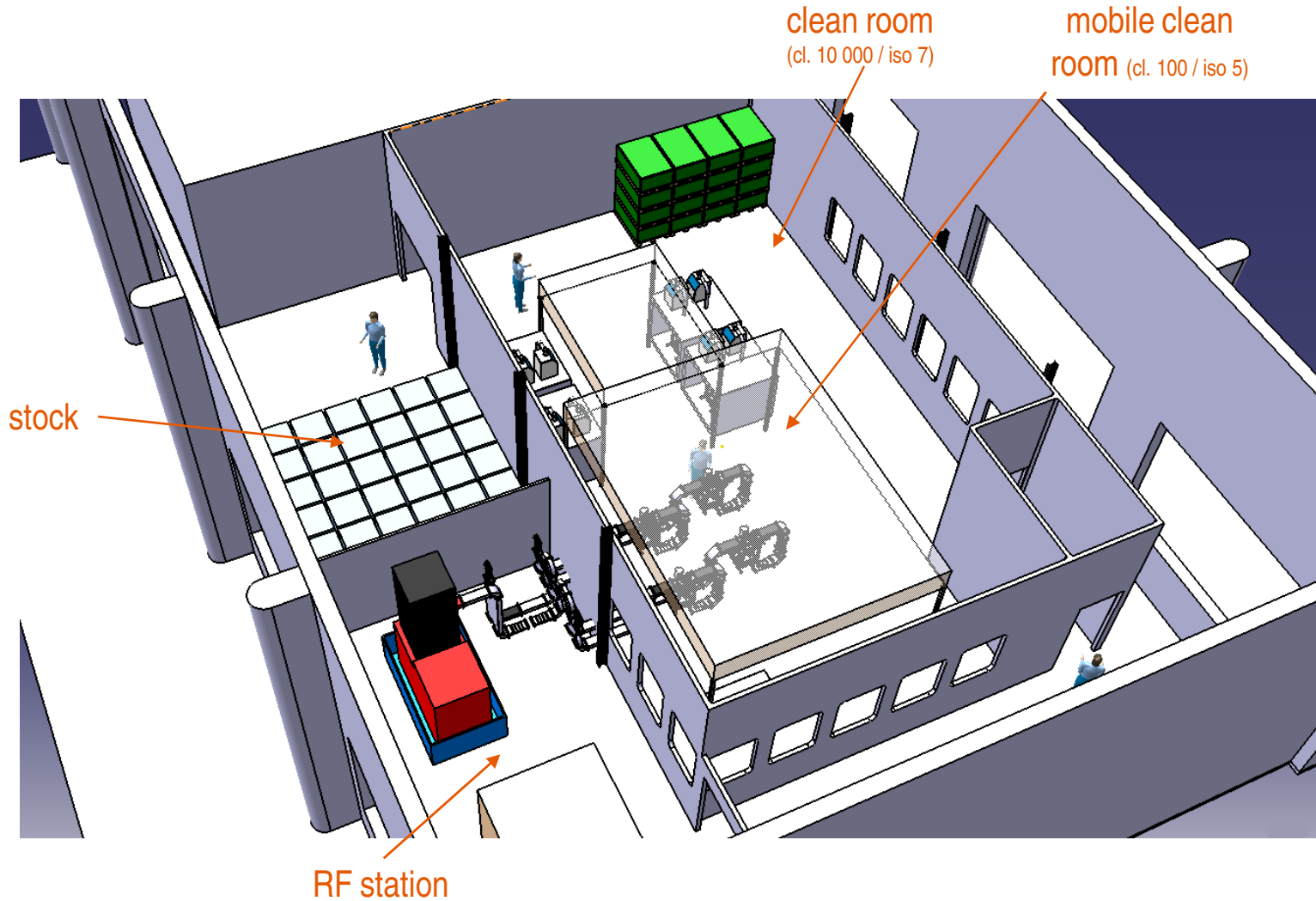
400 μs Pmax = 330 kW

500 μs flat top + flat top 100 μs, 200 μs, 400 μs, 800 μs Pmax = 250 kW

sweeps 500 μs + flat top 800 μs

Acceptance criteria for XFEL power couplers

Conditioning : Infrastructure



Managed by E. Genesseau (LAL)

Cleaning & Assembly

- Class 10 clean room
- US bath cleaning with detergent + high temperature
- Drying with filtered N2 and under laminar flux
- **Particle count**
- **Leak test**

Cleaning & assembly procedure @LAL



To be performed by the manufacturer !

Follow the procedure

 Nouvelle procédure montage conditionnement.doc Date : 07/01/2009

Etape 4	Compte de particules / pas assemblage des parties froides / étirage	Classe 10
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Préparation

N'oubliez pas que le bouchon d'arrêt à l'extrémité de la palle blindée est ouvert et dirigé vers le bas.

Matériel nécessaire

Les pièces de la type précédente

Tâches

Noter les références dimensions

Contrôle visuel :

- Effectuer un contrôle visuel des pièces livrées

Contrôle de particules des parties froides :

- Souffler les parties froides avec l'air tamisé, capturer de particules en face (Position 1)
- Lancer l'acquisition du compteur de particules
- Si au bout d'une minute il compte moins de 10 particules de taille >0.3µm, la partie contrôlée est considérée comme propre dans le cas contraire, le compteur réalise un cycle de mesure.
- Si au bout de 9 cycles, il compte toujours plus de 10 particules de taille >0.3µm, la pièce contrôlée sera alors considérée comme palle étalée de une être re-nettoyée.
- Recommencer les étapes précédentes pour les 3 positions suivantes :



Contrôle de particules de la transition de test :

- Insérer le tube de comptage
- Contrôler de la même façon la seconde partie froide

Contrôle de particules de la transition de test :

- Placer les tubes filtrés sur la transition de test après

Attention : Le piston doit être placé à l'opposé du port de pompage

- Faire le contrôle de particule de la transition dans les 3 positions suivantes :



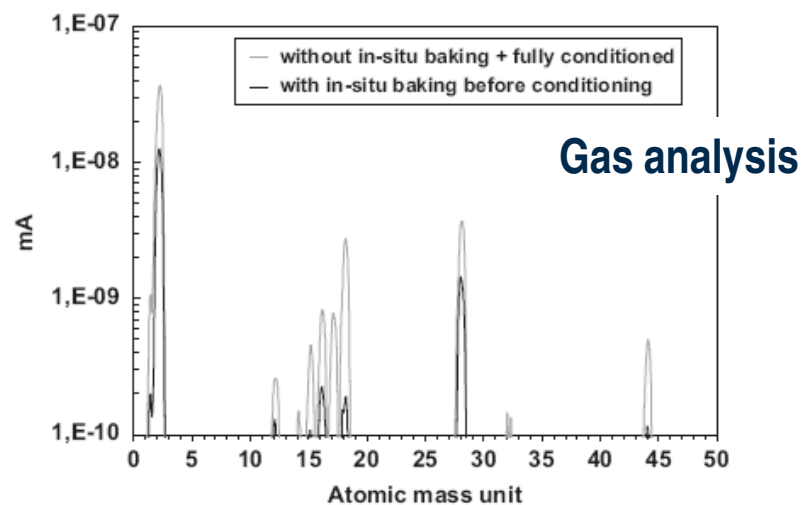
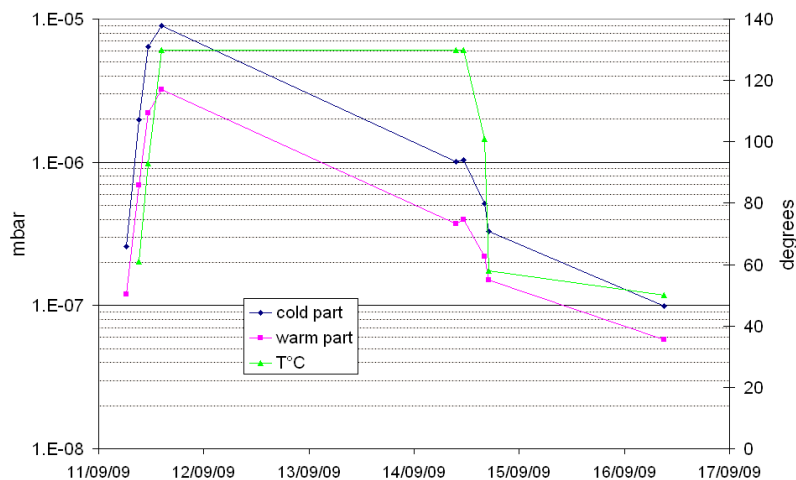
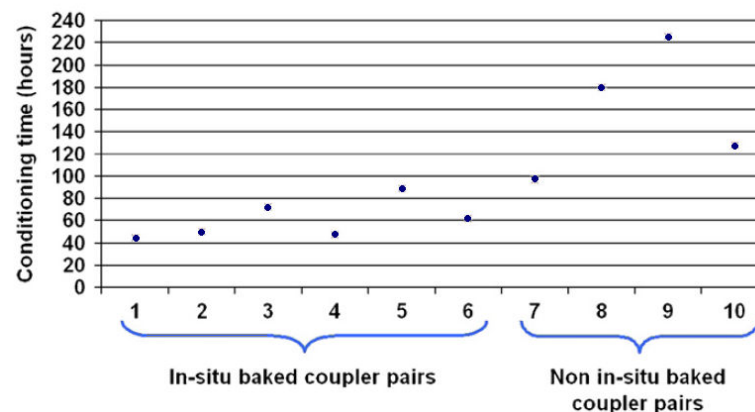
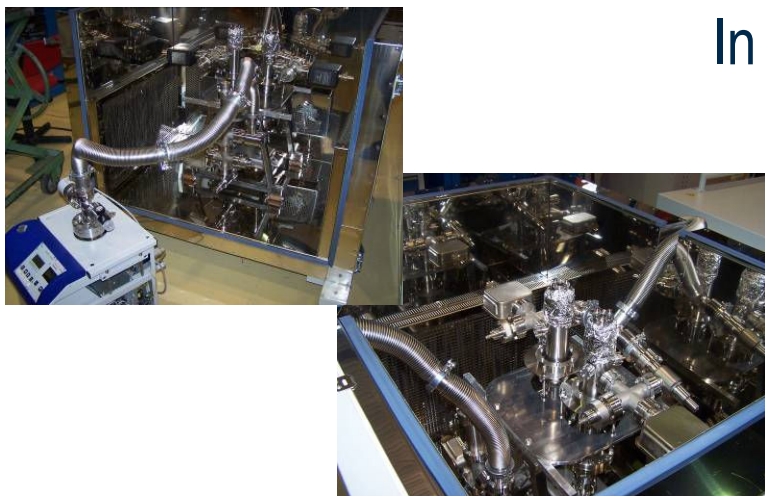
Rédigé par : M.Lacroix

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Acceptance criteria for XFEL power couplers

Conditioning : lessons learned from TTF3 couplers

In situ baking



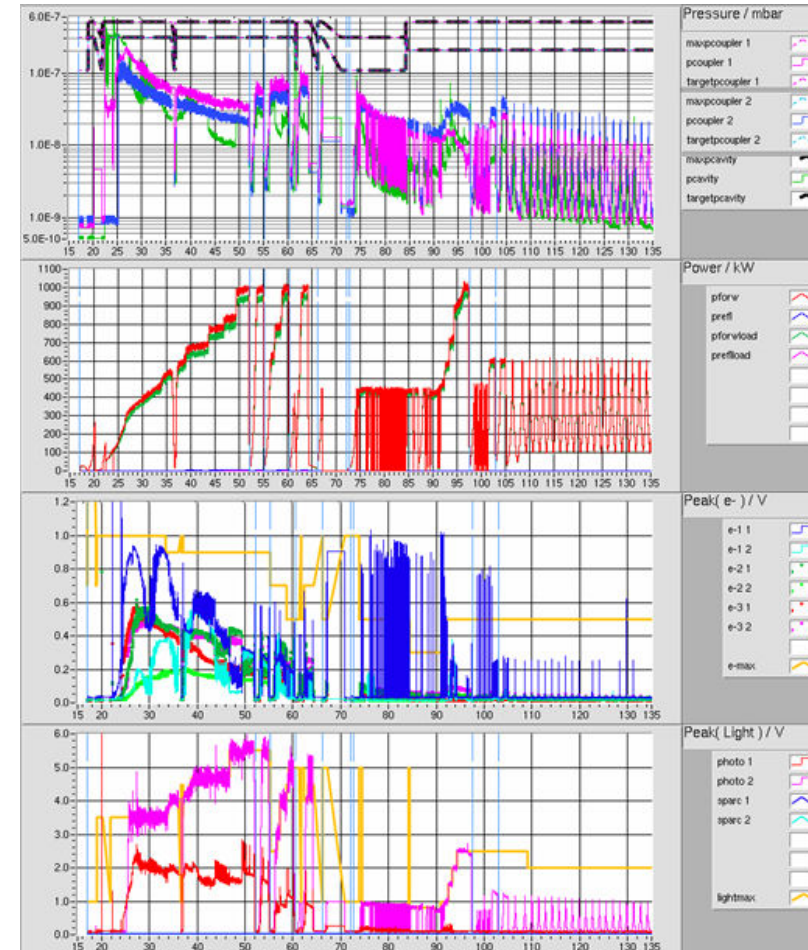
H. Jenhani et al., NIM A 595 (2008)

Acceptance criteria for XFEL power couplers

Accepting a coupler : good or excellent?

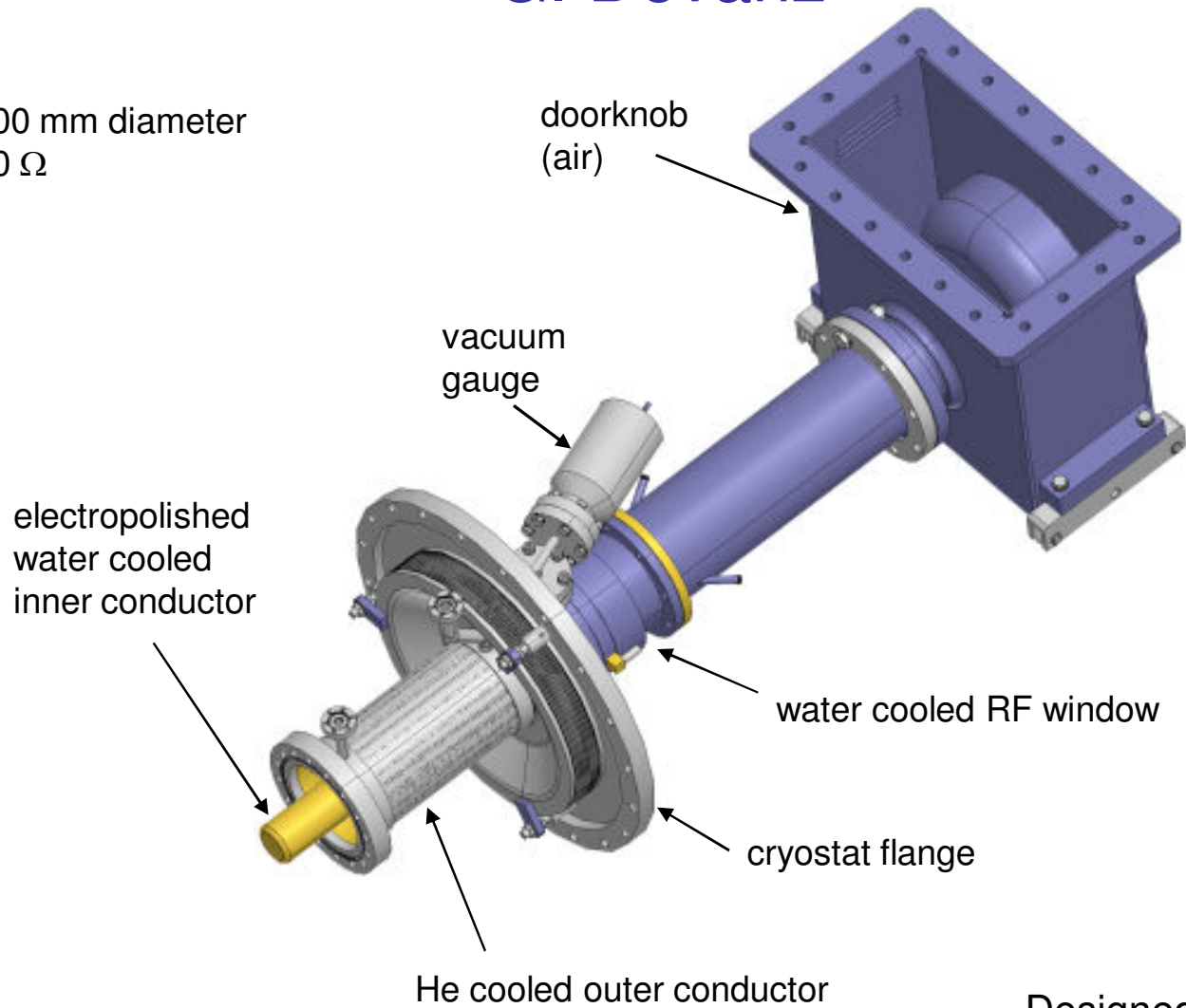
- *Mechanical : dimensions, visual inspection*
- *Material tests (TiN & Cu coatings)*
- Following the cleaning and assembly procedure
- Particle count
- Leak tests
- In situ baking gas analysis
- **Time needed to achieve given power level**
- **Total conditioning time => excellence**
- **Number of interlocks => refusal**

Example of refused coupler



704 MHz -1 MW power coupler G. Devanz

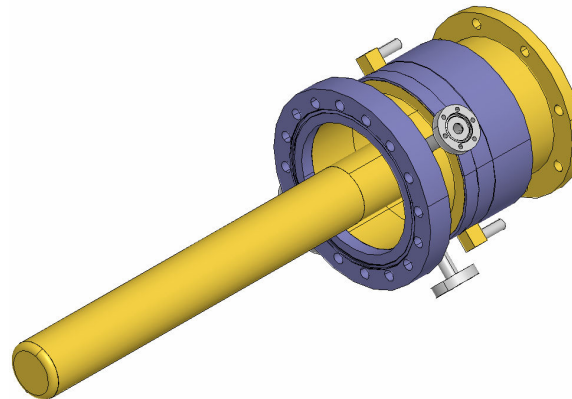
100 mm diameter
50 Ω



Designed for 1MW, 10%DC

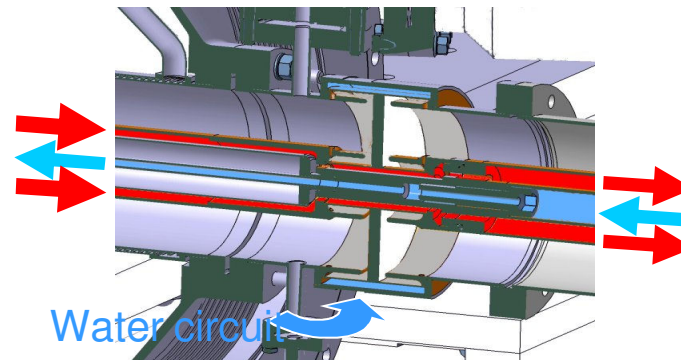
Coupler - window

- KEK like design , disk window matched with chokes
- water cooling of the antenna and the internal braze of the ceramic



internal conductor dissipation
for 100kW average incident power

	P int (W)	dens. int (W/m ²)
TW	100	870
SW	200	1740



Coupler & stand preparation

- parts ultrasound cleaning, high purity water rinsing
- assembly in clean room (couplers+coupling box)
- couplers always handled in vertical position
- clean room compatible handling tools
- rail and cart system to move heavy parts
- 200 °C 48h in-situ baking of the vacuum parts

Assembly of the couplers in class 10 clean room



704 MHz coupler test stand

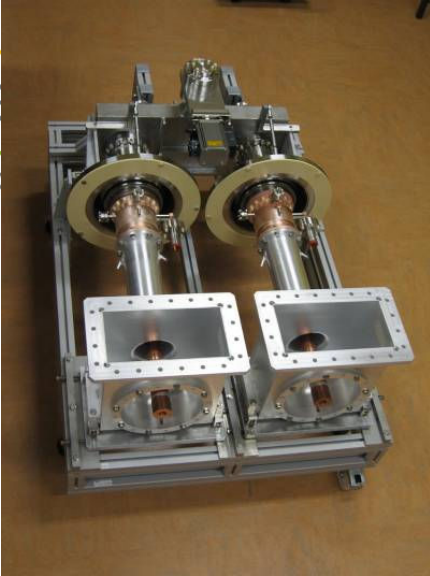
Couplers are conditioned in horizontal position

RF power source : 1 MW klystron 2ms 50Hz

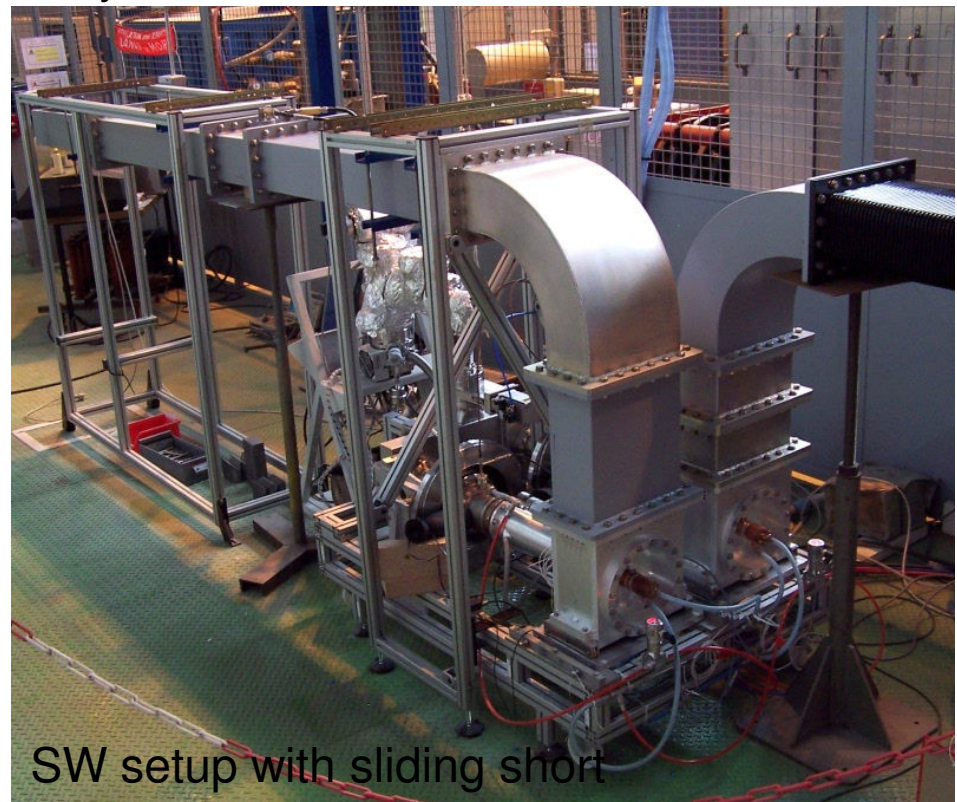
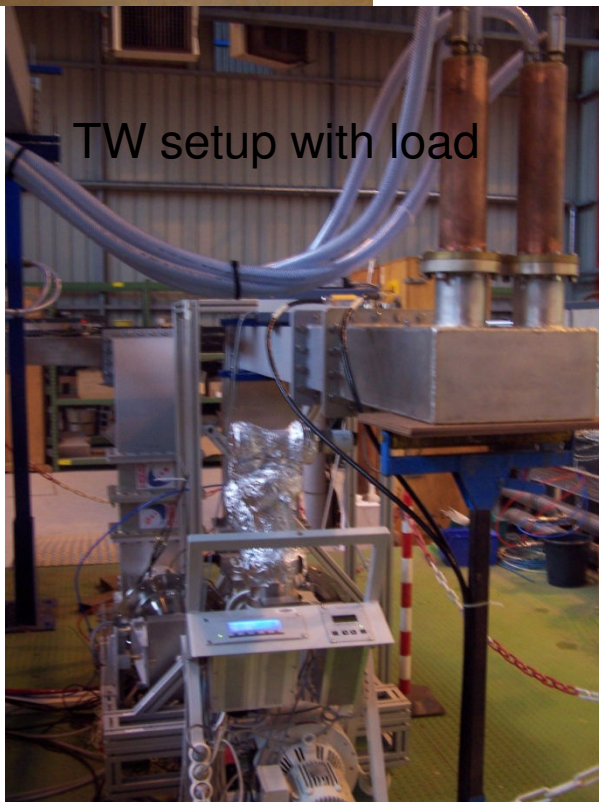
Pulsed HV power supply : 110 kV 2.5 A HVPS and modulator

Circulator commissioned with full reflected power, all phases

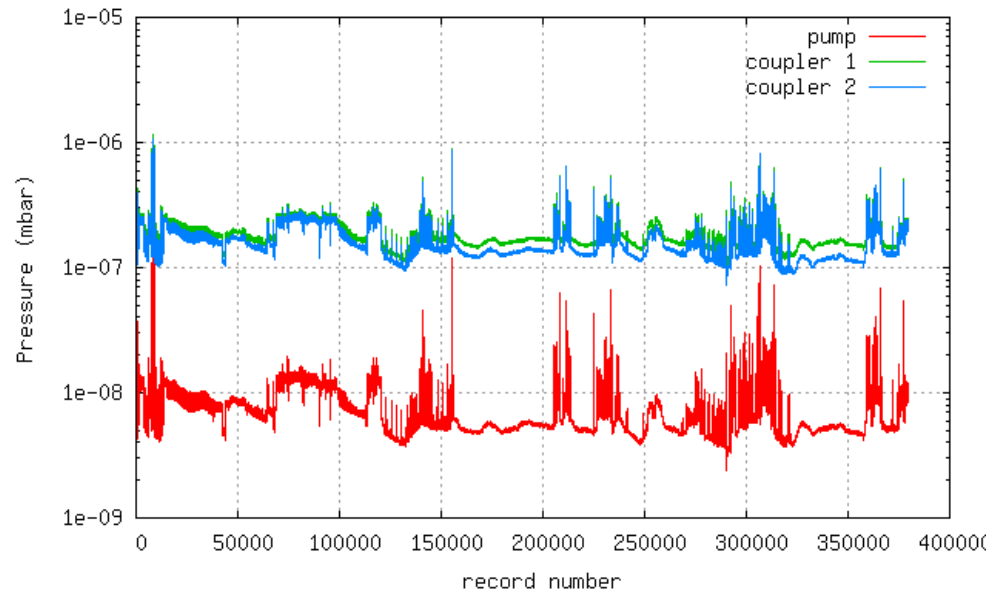
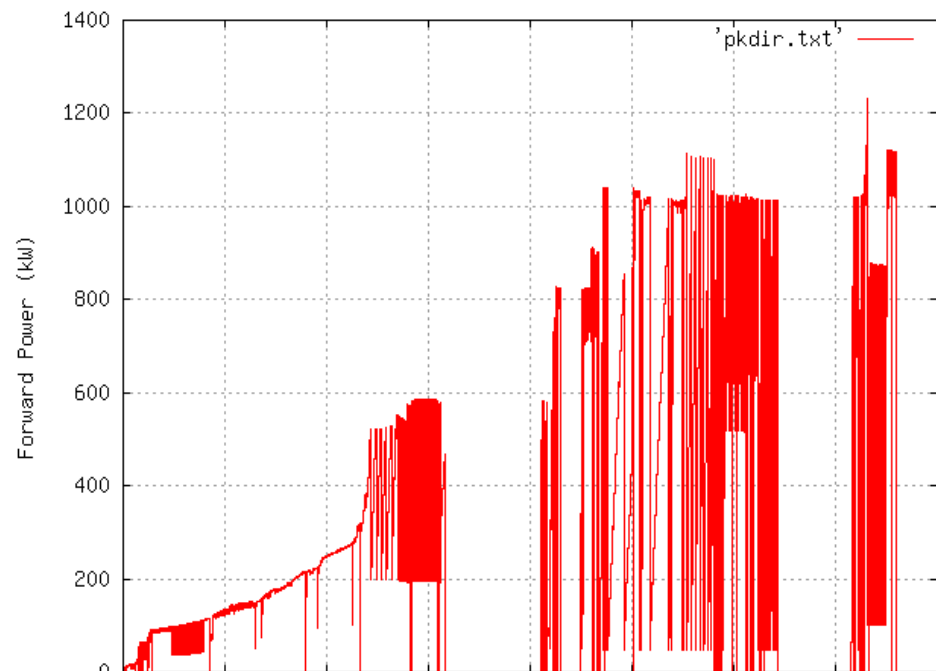
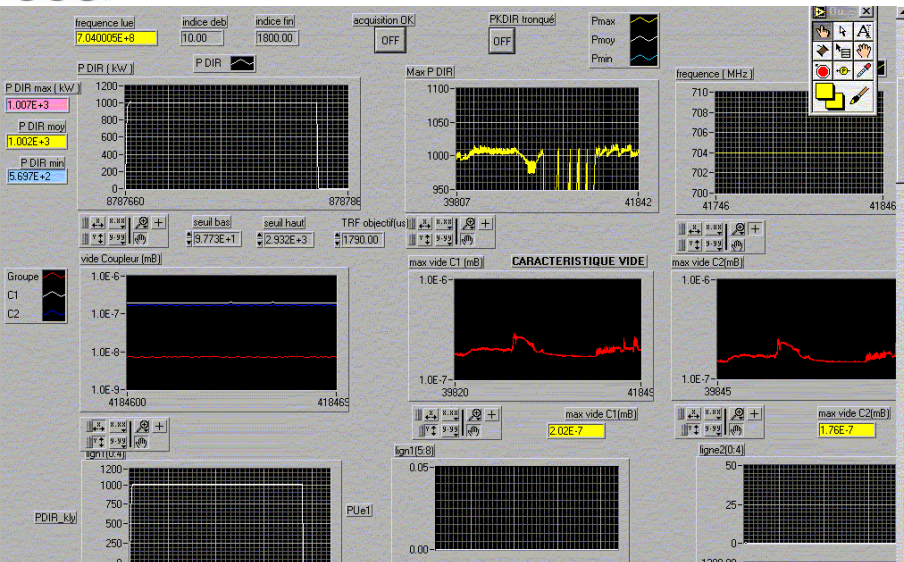
Oil-free pumping (high pressure turbomolecular+scroll pump)



Fully functional test stand



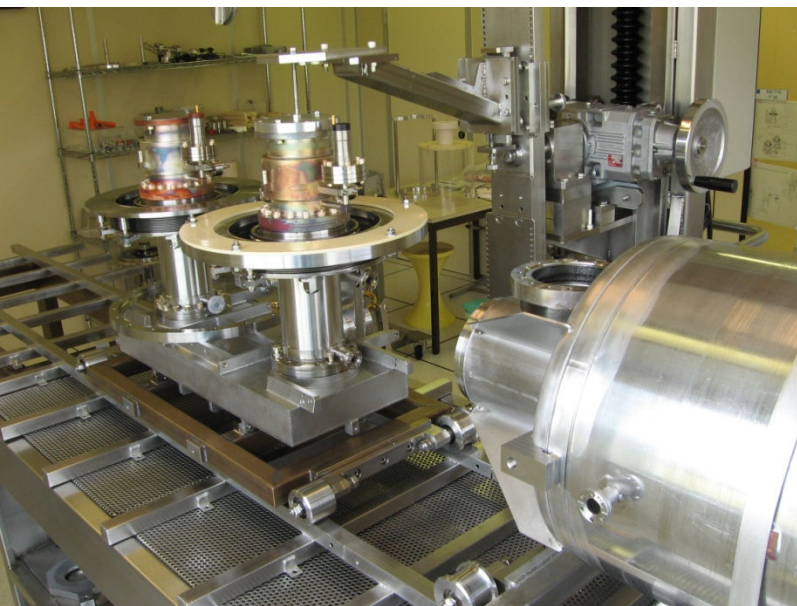
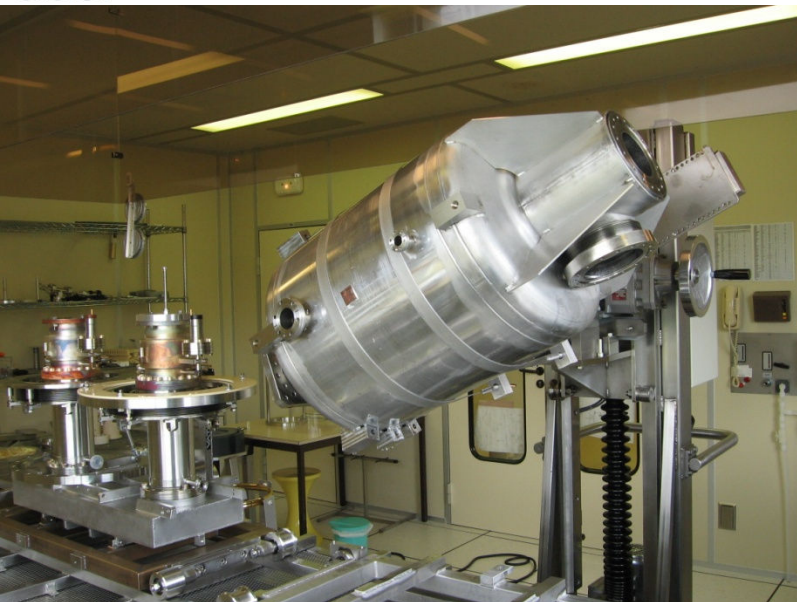
Coupler conditioning



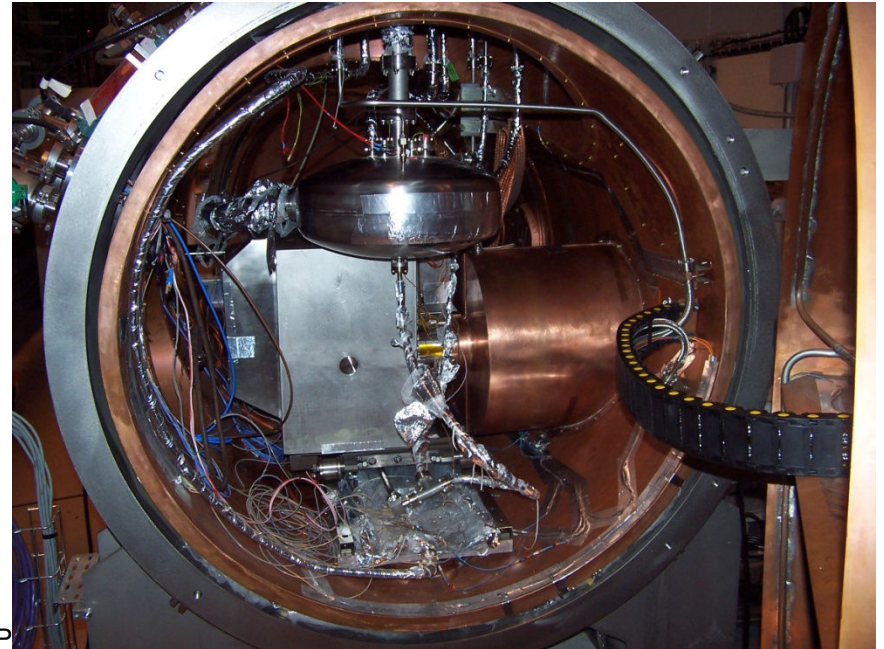
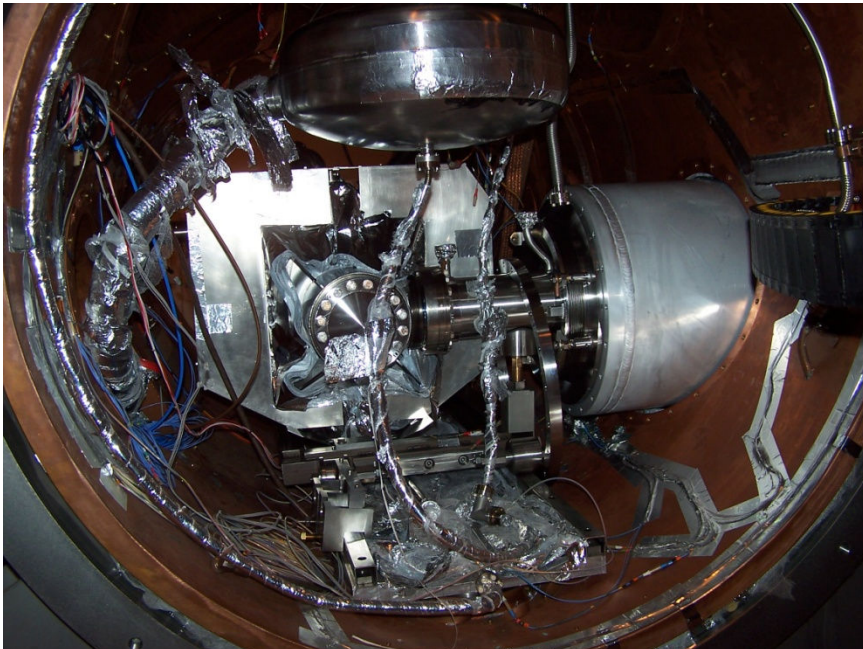
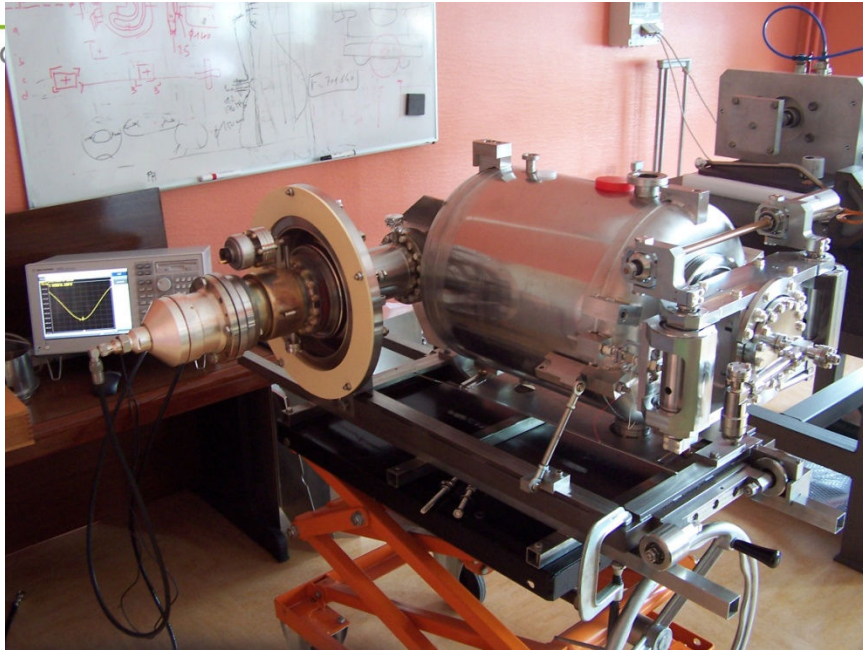
- Maximum en TW 1.2 MW peak @10% DC
- Total duration. 300h
- SW conditioning stopped due to HVPS failure in march09, then had to proceed with the coupler installation on the test SC cavity
- Repair of the 110kV 2.5A still going on, coming back end of november
- Othe HVPS were available at the lab to operate with a lower duty cycle.

Coupler transfer on the test cavity

In class 10 clean room



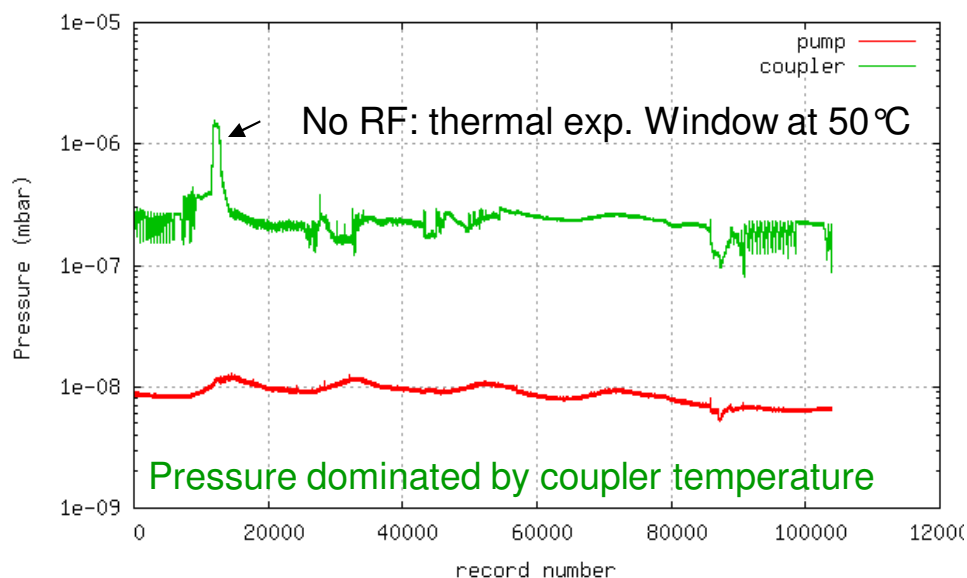
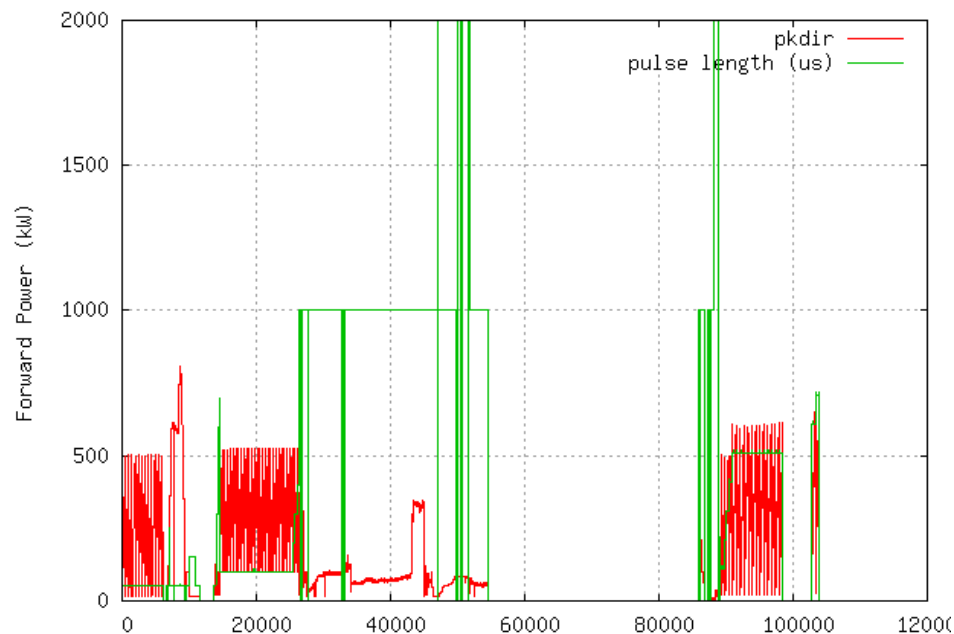
Cryolab configuration for pulsed tests



Conditioning on cavity

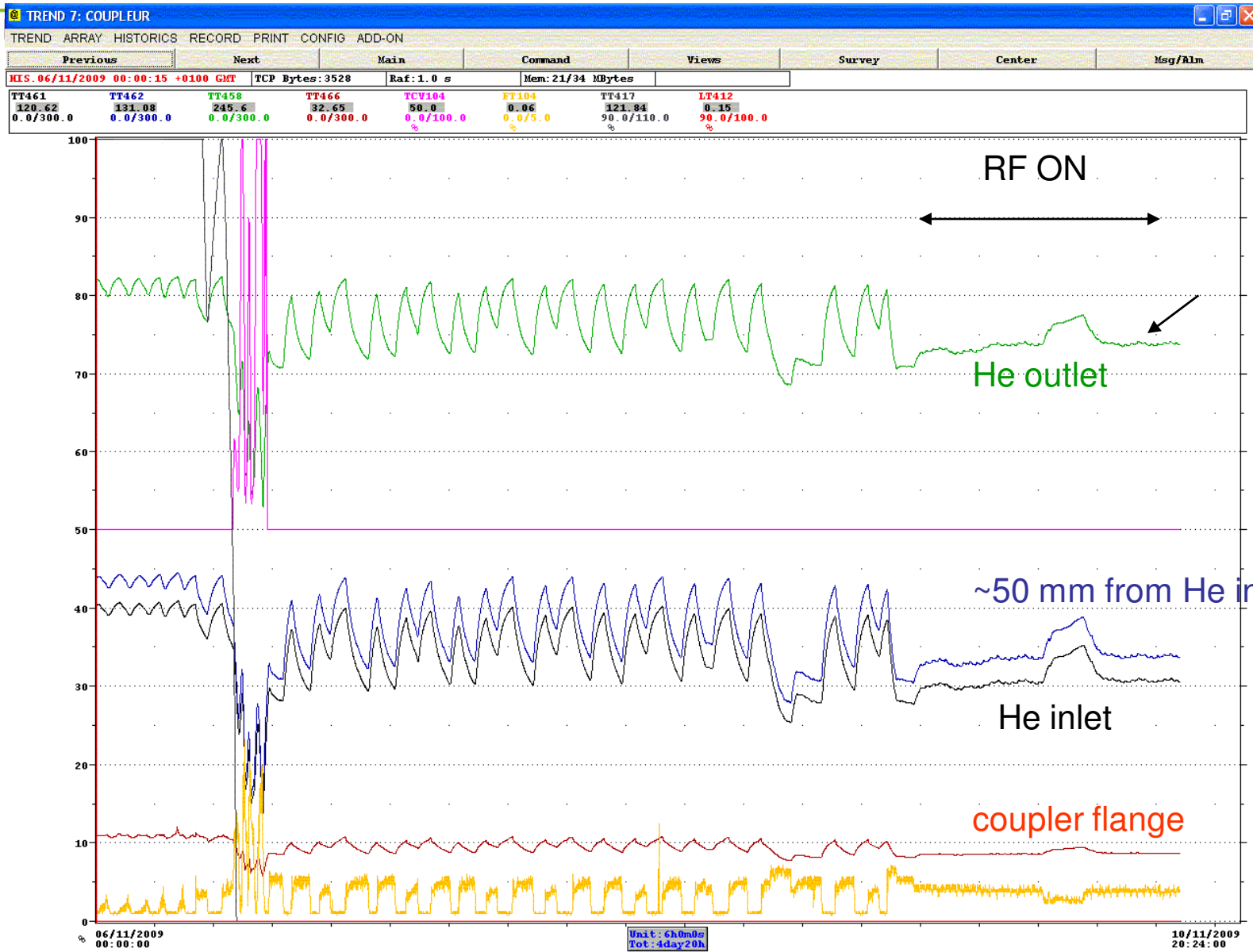
- No conditioning done at room temperature on cavity
- Cool down of Cryholab with only the vacuum part of the coupler assembled to monitor the cavity displacement, only 0.1 mm at the level of the coupler window
- Assembly of doorknob and coaxial extension of the coupler.
- Conditioning with reduced duty cycle (spare HV power supply) in full reflection (detuned cavity)
 - start with 100 μ s pulses 5 Hz ramping power from 20 to 500 kW
 - increase pulse length up to 1 ms, same power ramping :
- conditioning with the cavity/ klystron tuned at 703 MHz, 1.8 K
 - 1ms pulses : up to 80 kW (too much Lorentz detuning on the cavity without compensation)
 - 2ms pulses: 240kW/80kW
- This week : resume of the pulsed tests after cryogenics and HPVS downtime
- Run with detuned cavity going on now 700 μ s, 600kW, 5Hz Monday, the coupler is conditioned, no more activity

HIPPI couplers conditioning on cryholab



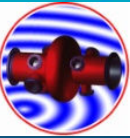
Downtime due to HVPS failure mainly

Thermal behavior



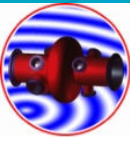
Conclusion

- Couplers performed as expected on the test stand achieving 1.2 MW peak, 120kW average
- After installation on the beta 0.5 cavity in the horizontal test cryostat Cryholab, very small amount of conditioning was necessary to operate in full reflection, well above the necessary power for cavity operation
- Cryo operation was done using a reduced duty cycle (most of the time 1 ms pulses at 5Hz) due to main HVPS failure, and the use of a lower spec'd spare HVPS
- Higher average power test will be resumed as soon as we install the main HPVS again in december
- One water leak occurred on the air side due to a misalignment of the inner conductor of the doorknob extension. Most probable scenario: gap between conductors->arcing->arc through the gasket drills a hole-> water leak. This can be avoided with a modification of the dual water/RF connection, the vertical position of the coupler and a shorter doorknob extension.
- Downtime due to High Voltage Power Supplies failure mainly



High average power couplers

SPL possible designs



SPL requirements

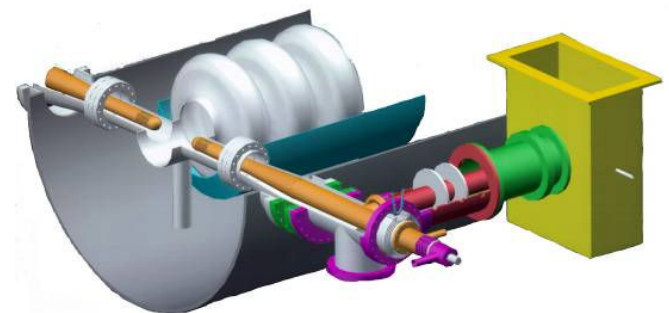
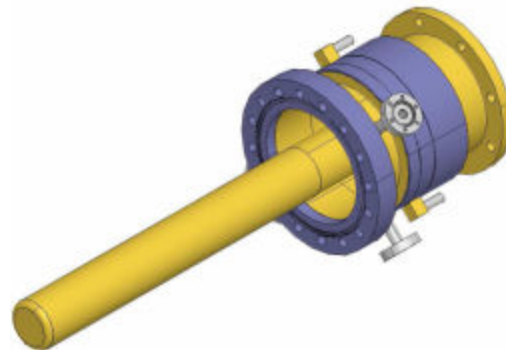
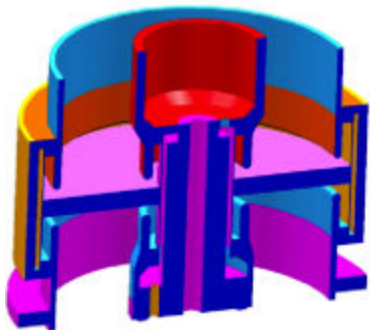
f_0	704.4 MHz
Low Power SPL	2.5 kW average 600 kW pulsed $0.4 + 1.2 + 0.4 = 2.0$ ms 2 Hz (500 ms)
High Power SPL	100 kW average 1000 kW pulsed $0.4 + 1.2 + 0.4 = 2.0$ ms 50 Hz (20 ms)
Cavity design gradient	19-25 MV/m
Q_{ext} of input coupler	$1 \cdot 10^6$ for LP-SPL and HP-SPL
Input line \emptyset	$100 / 43.5 \text{ mm} = 50 \Omega$
Waveguides	WR 1150

Source : <https://twiki.cern.ch/twiki/bin/view/SPL/SplWeb>



Coaxial Disk windows

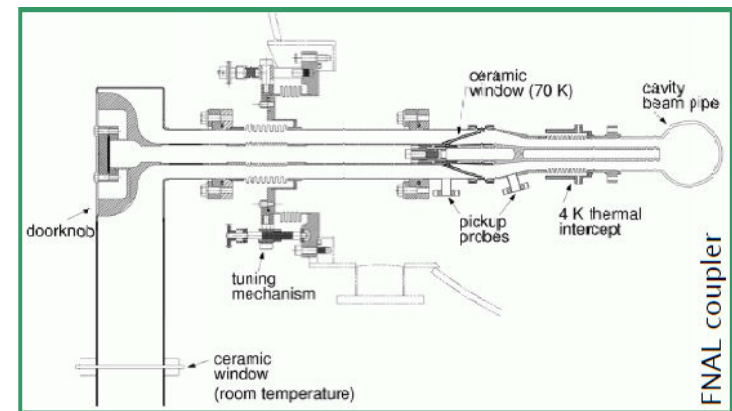
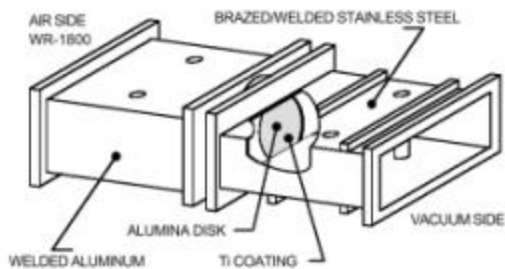
Coupler	Frequency [MHz]	Average Power [kW]	Peak power [kW]	# in operation or constructed
APT	700	1000	1000	2
SPS	200	550	800	16
KEKB	509	300	1420	8
CEA-HIPPI	704	120	1200	2
IHEP	500	150	270	2
JPARK	972	30	2200	23
SNS	805	78	2000	93

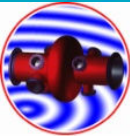




Waveguide windows

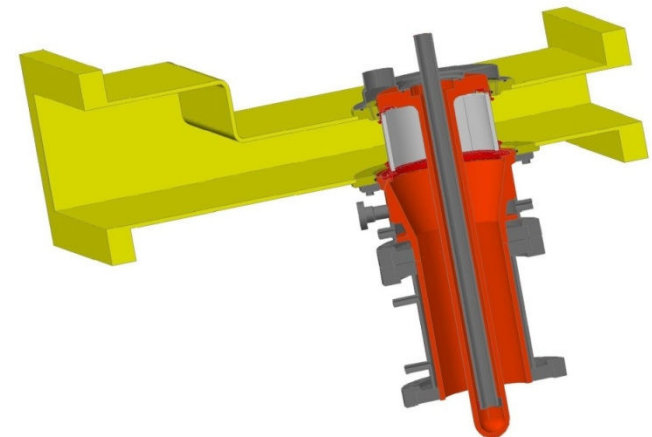
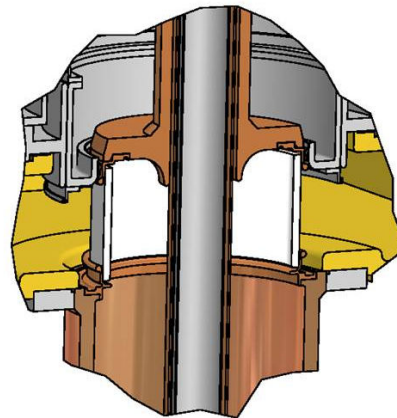
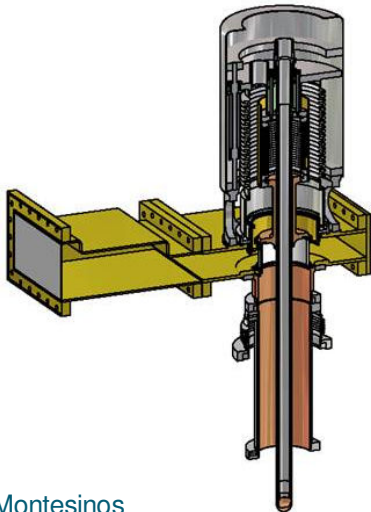
Coupler	Frequency [MHz]	Average Power [kW]	Peak power [kW]	# in operation or constructed
SPS	801	225	225 (more ?)	8
Cornell	500	350	350	4
FNAL / TTF II	1300	4.5	1000	32





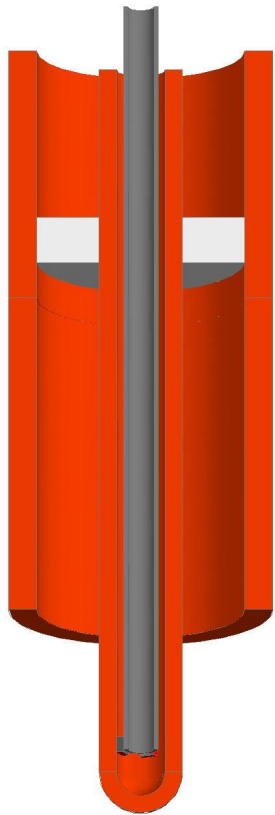
One cylindrical window

Coupler	Frequency [MHz]	Average Power [kW]	Peak power [kW]	# in operation or constructed
ESRF / Soleil	352	550 sw cw	Under construction	64
LHC	400	550 sw cw, (i.e 2200 tw cw)	i.e. 2200 tw cw	16
LEP	352	550 tw cw	565 tw cw	252
SPS (1976-2000)	200	375	500	16





Fixed versus Adjustable coupler



Disk window - fixed coupler

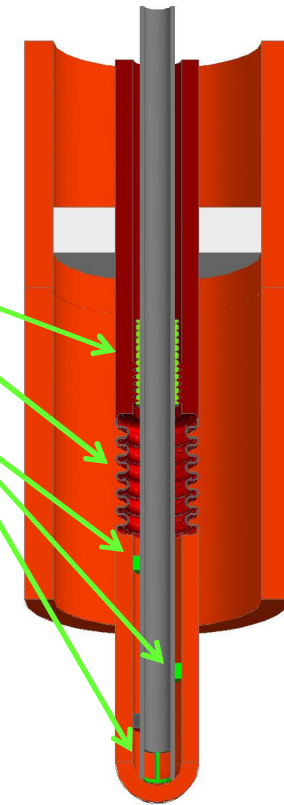
- An adjustable coupler is not a variable coupler (only few mm of fine coarse)

- However, in addition to the already complex line :

- Moving system not stressing the ceramic
- Below, more EB welding
- Alignment system to keep the bottom part of the antenna at the right place under the below

- This will :

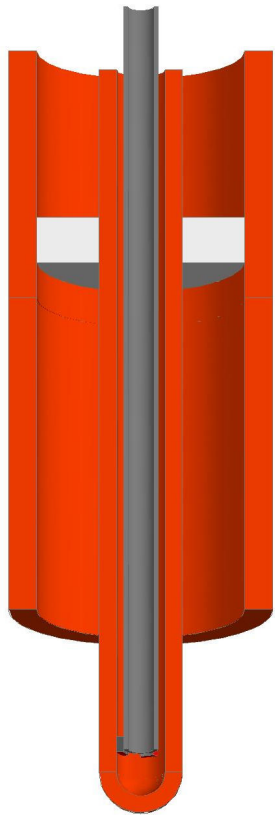
- increase the complexity
- Increase the number of mechanical operations
- Increase the risk of pollution of the coupler
- Increase the risk of vacuum leak
- Subsequently increase the total price



Disk window - adjustable coupler



Fixed versus Adjustable coupler



Disk window - fixed coupler

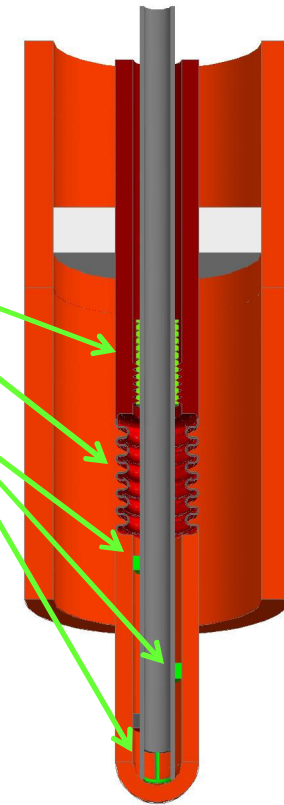
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- This will :

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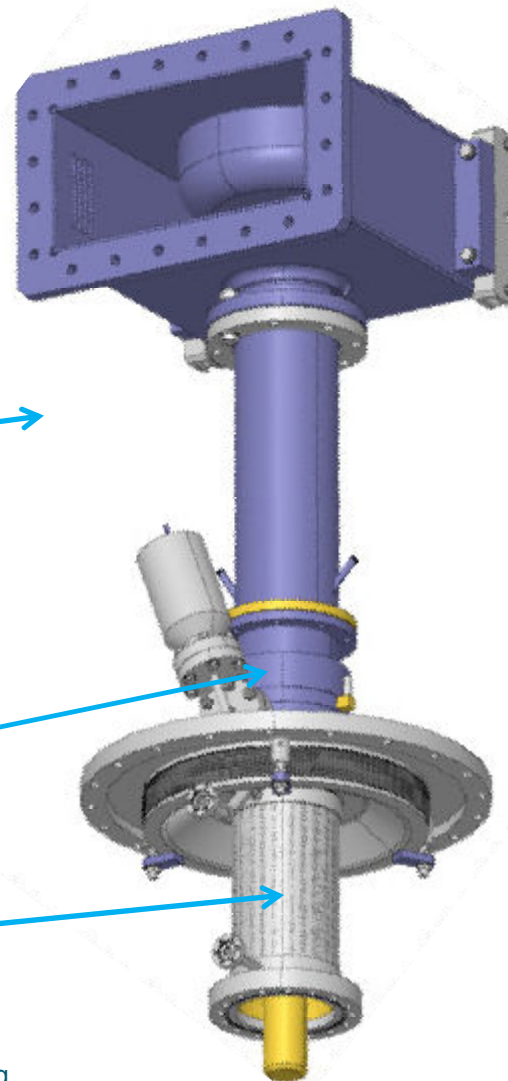
Disk window - adjustable coupler



Proposed design

Coupler Working Group's conclusions:

- For mechanical reasons, **easier to have the coupler mounted vertically**, less stress to the antenna
- **Preferably above the cavity**, allows a good access, also the preferred solution for the tunnel integration
- Access from the bottom is less convenient for work with the air side and for connecting the waveguides
- Only one ceramic (very important impact onto the cavity assembly process)
- To ensure the thermal transition, a double walled tube will be connected between the cavity and the cryomodule (as already experienced with LHC, CEA Saclay)





Draft time table

Coupler design review
March 2010

ID	Task Name	Qtr 4, 2009	Qtr 1, 2010	Qtr 2, 2010	Qtr 3, 2010	Qtr 4, 2010	Qtr 1, 2011	Qtr 2, 2011	Qtr 3, 2011	Qtr 4, 2011	Qtr 1, 2012	
		Oct Nov Dec	Jan Feb Mar	Apr May Jun Jul	Aug Sep	Oct Nov Dec	Jan Feb Mar	Apr May Jun	Jul Aug Sep	Oct Nov Dec	Jan Feb Mar	
1	SPL CEA Saclay couplers	[Timeline bar]										
2	Design modification for SPL cryomodule	[Timeline bar]										
3	Construction and assembly	[Timeline bar]										
4	Tests on warm cavity	[Timeline bar]										
5		[Timeline bar]										
6	SPL Other designs	[Timeline bar]										
7	Design	[Timeline bar]										
8	Construction and assembly of chosen designs	[Timeline bar]										
9	Tests on warm cavity	[Timeline bar]										
10		[Timeline bar]										
11	Warm tests cavities	[Timeline bar]										
12	Design	[Timeline bar]										
13	Construction and assembly	[Timeline bar]										

Interfaces definition
for end 2009

8 couplers fully RF conditioned
for beginning 2012



SPL main power coupler

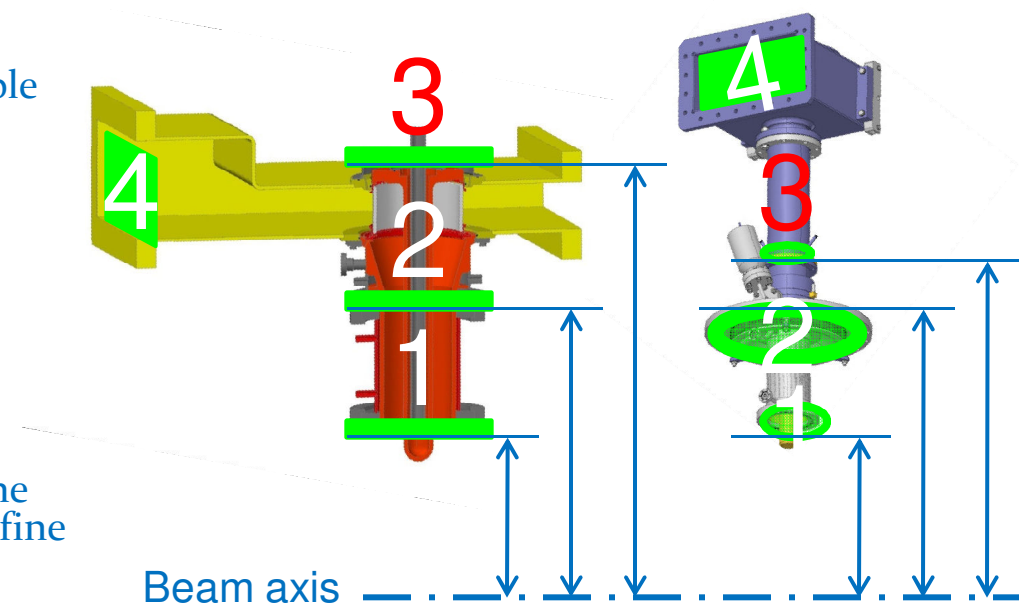
integration requirements



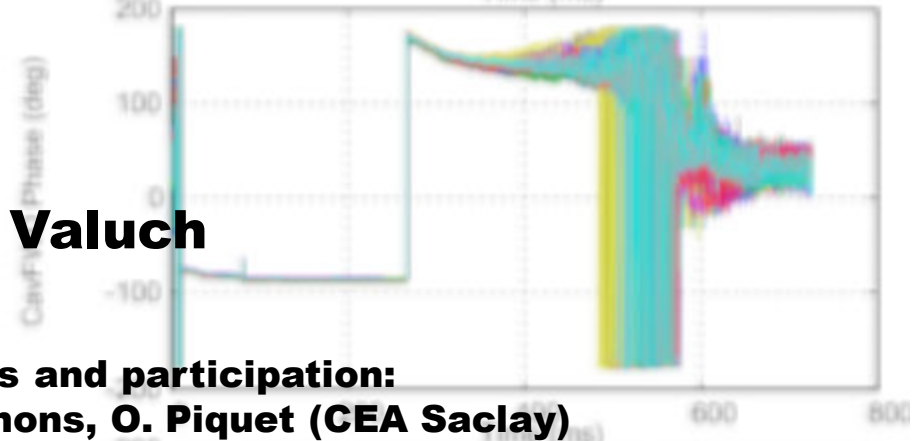
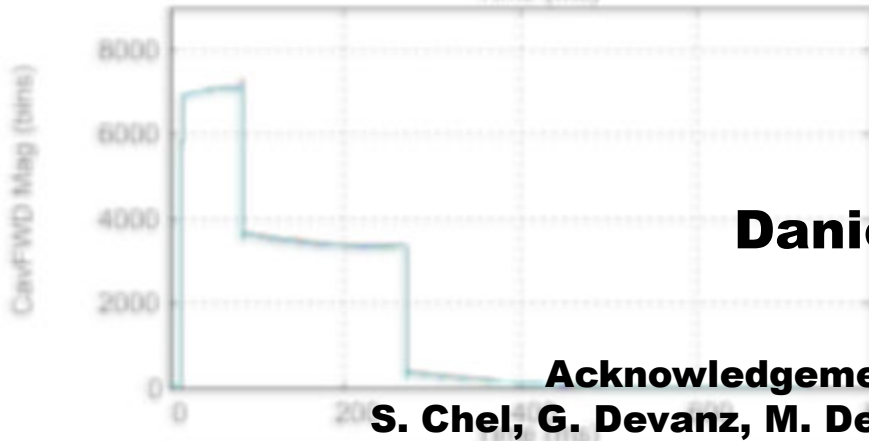
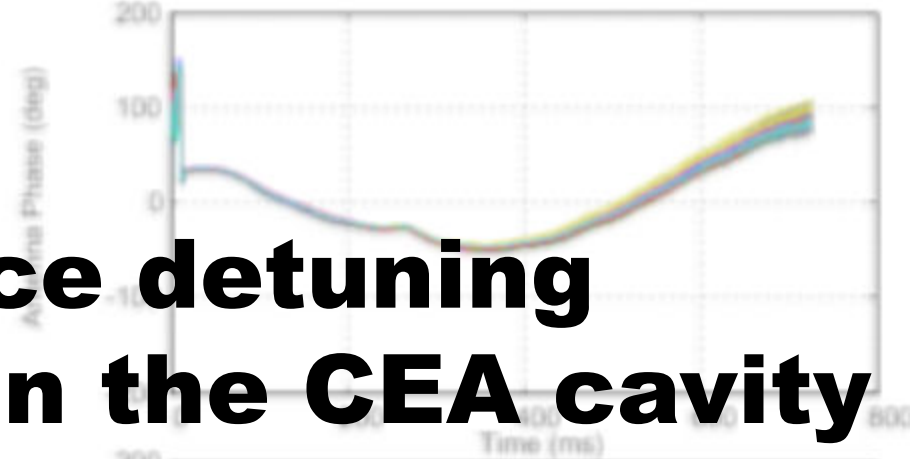
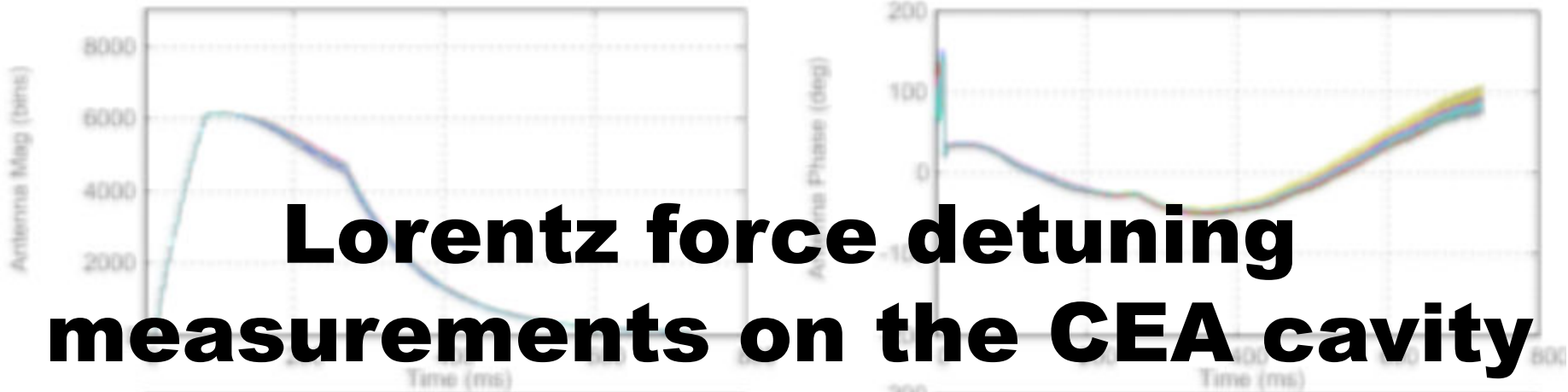
Cryomodule connectivity

- Prior to all that process, including the design of the coupler, the main interfaces still have to be decided as soon as possible:

- 1/ Cavity flange, lower part of the double walled tube
- 2/ Cryostat flange, upper part of the double walled tube
- 3/ Total height of the coupler for cryomodule integration
- 4/ Waveguide flange, will impact on the waveguide distribution, and will define the needed supporting tool



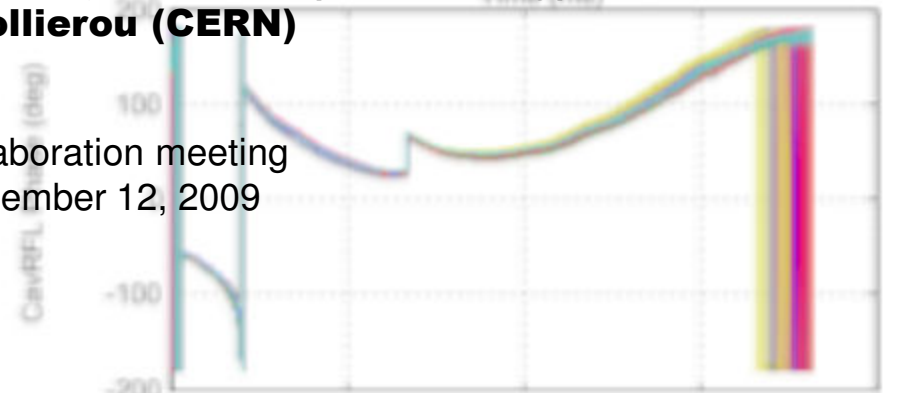
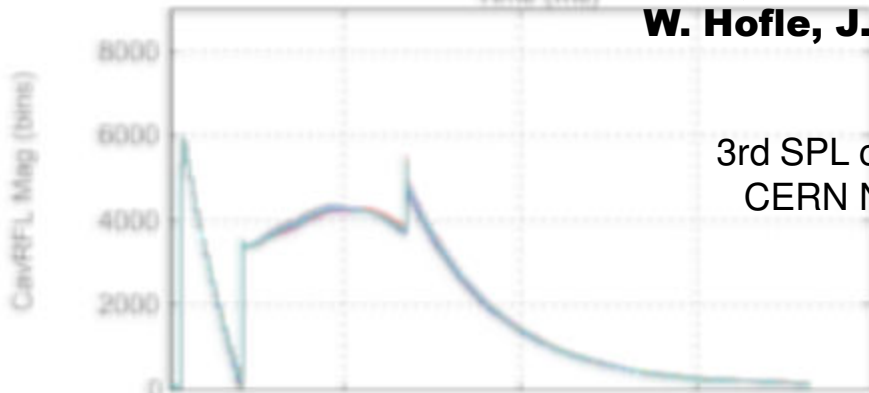
Lorentz force detuning measurements on the CEA cavity



Daniel Valuch

**Acknowledgements and participation:
S. Chel, G. Devanz, M. Desmons, O. Piquet (CEA Saclay)
W. Hofle, J. Lollierou (CERN)**

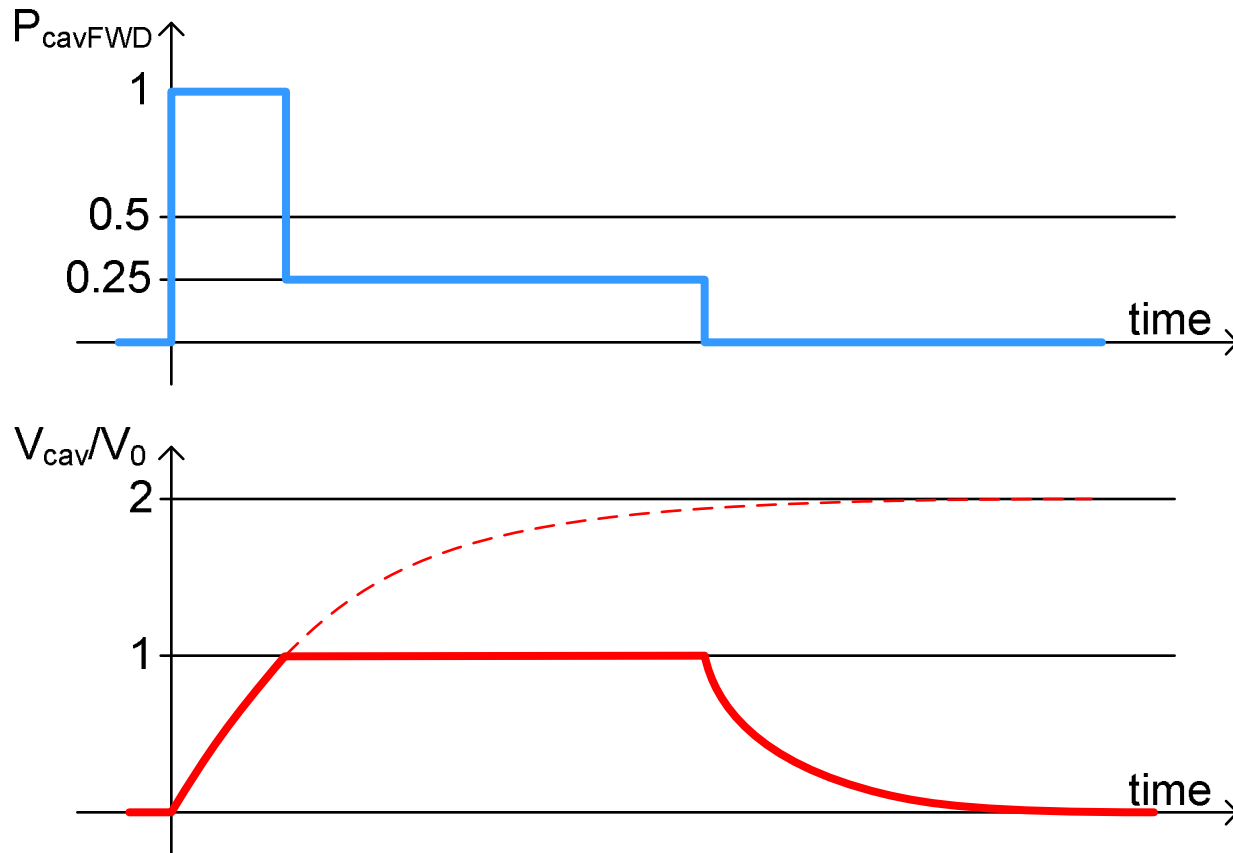
3rd SPL collaboration meeting
CERN November 12, 2009



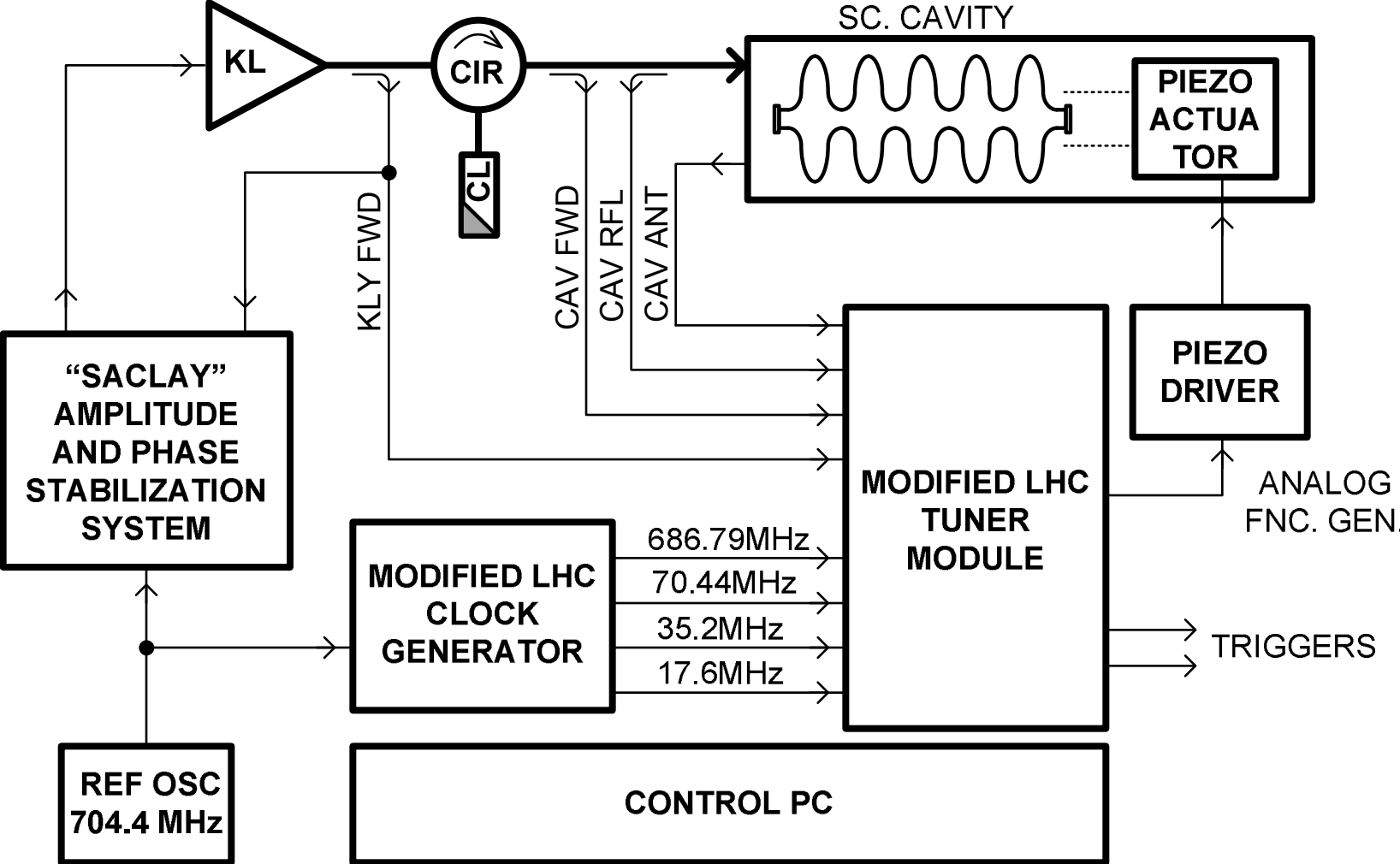
This project has received funding from the European Community's Seventh Framework Programme (FP7/2007-2013) under the Grant Agreement n° 212114

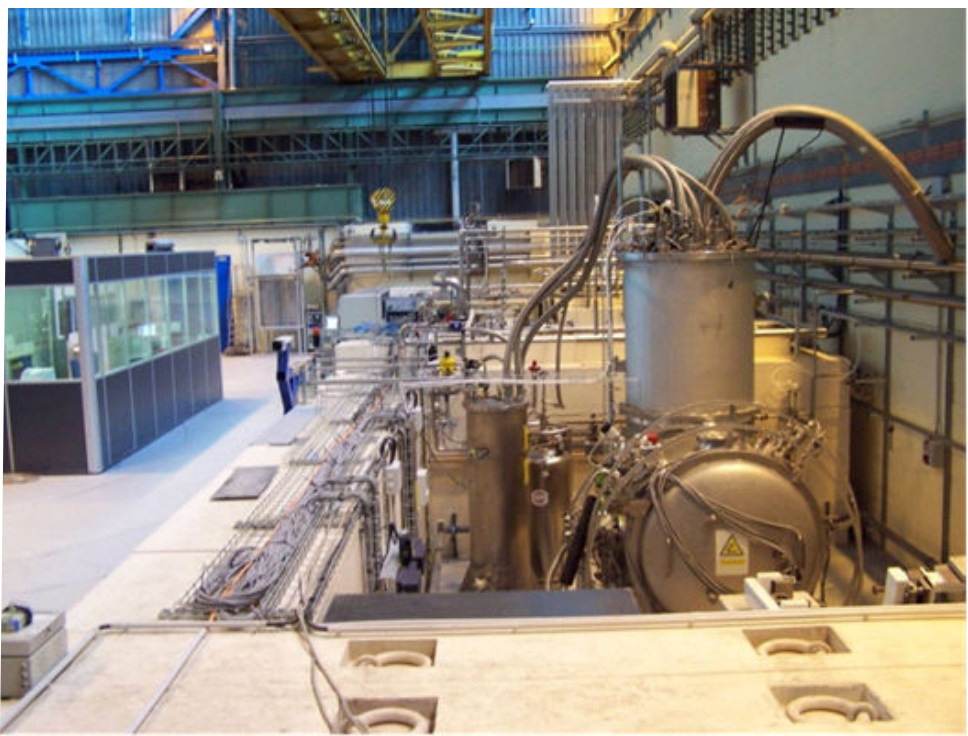
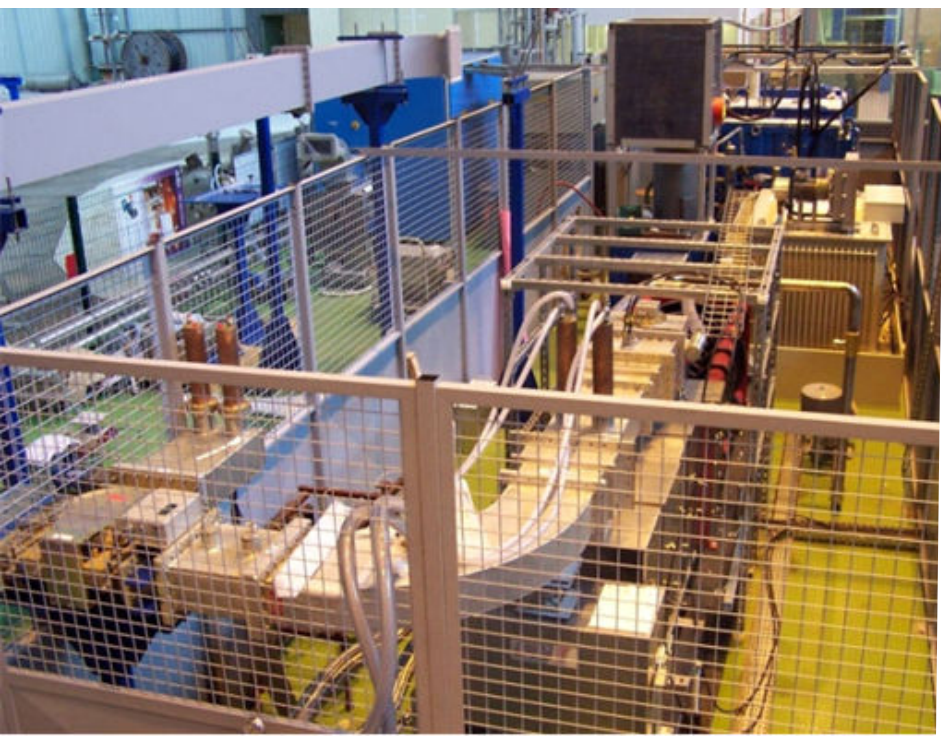
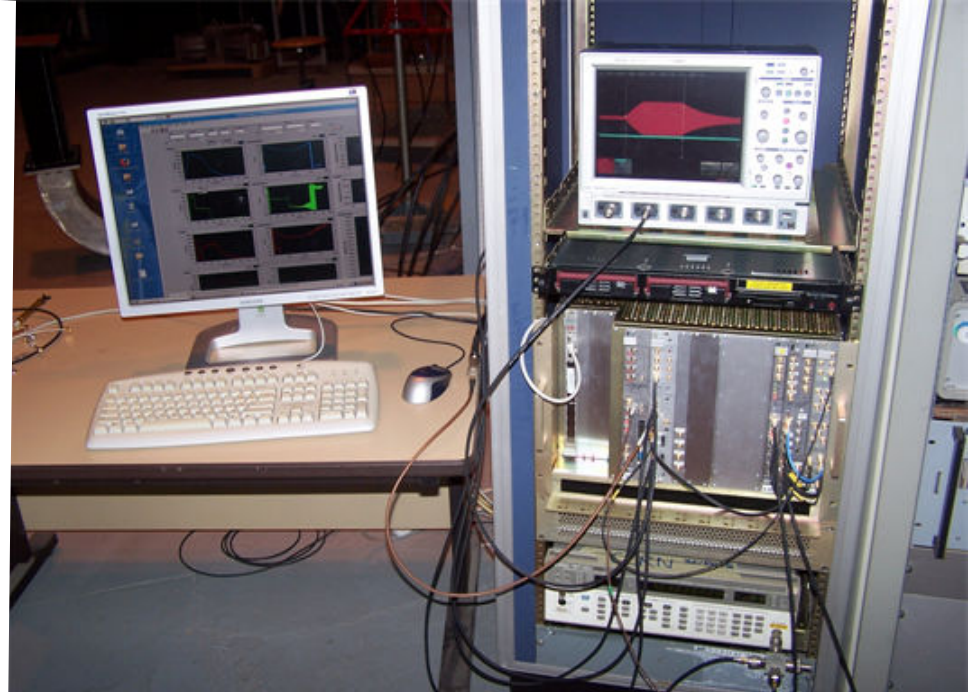
Typical waveforms

- Cavity filling transient with “simulated” beam



Measurement setup

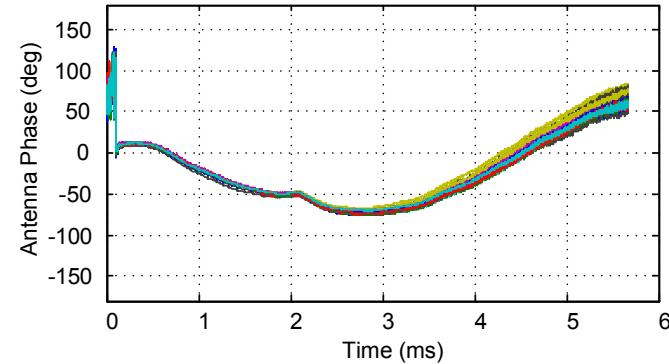
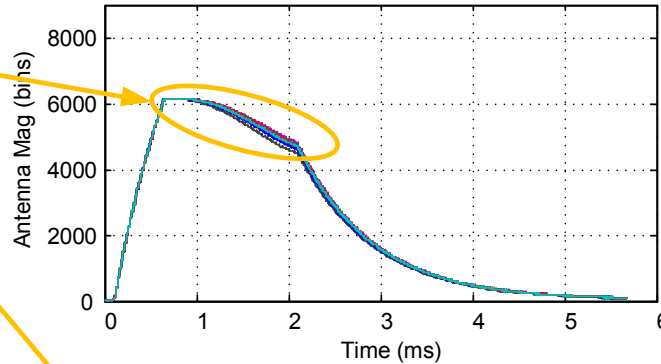




Preliminary results

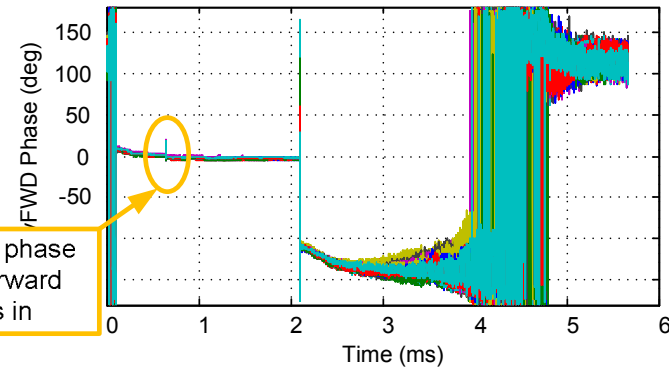
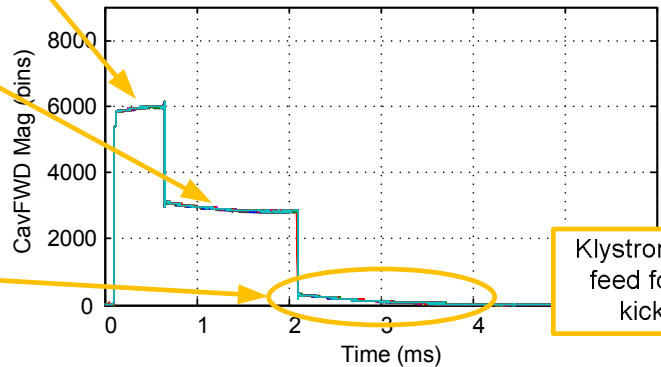
- Acquired a typical linear pulse

Strong Lorentz force detuning



- The beam was simulated by lowering the forward power to nominal

Cavity filling

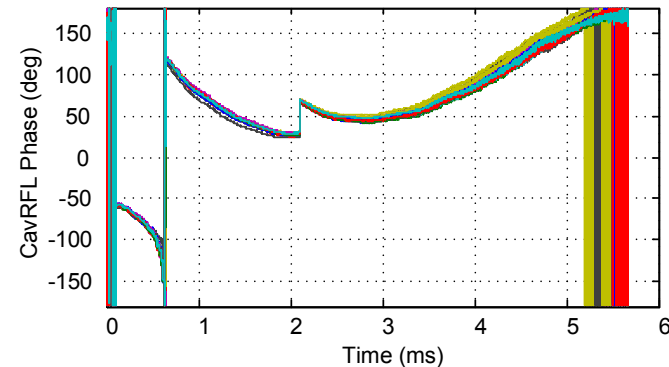
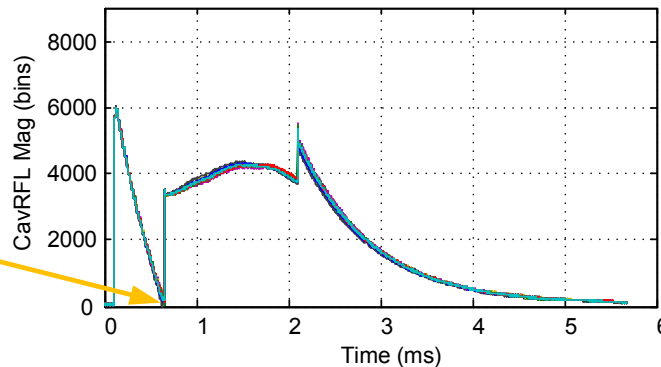


- A set of measurements showing pulse reproducibility

Simulated beam pulse

Coupler directivity will be numerically compensated in post processing

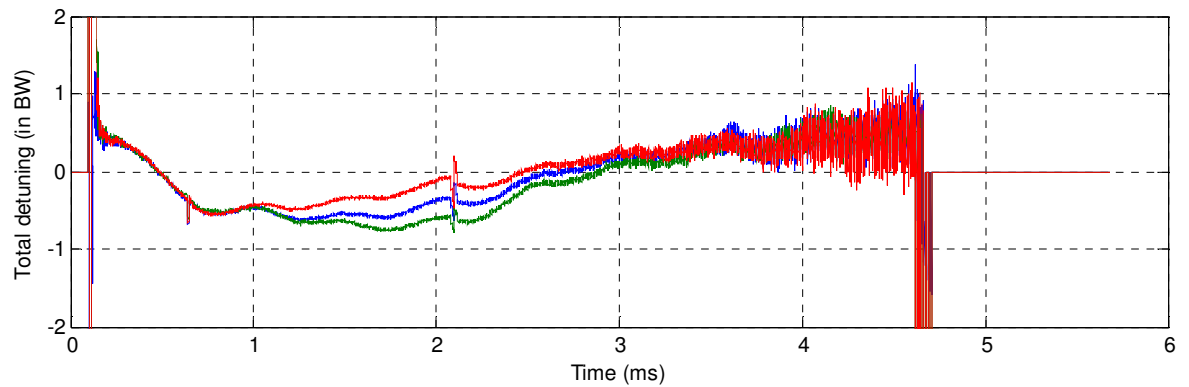
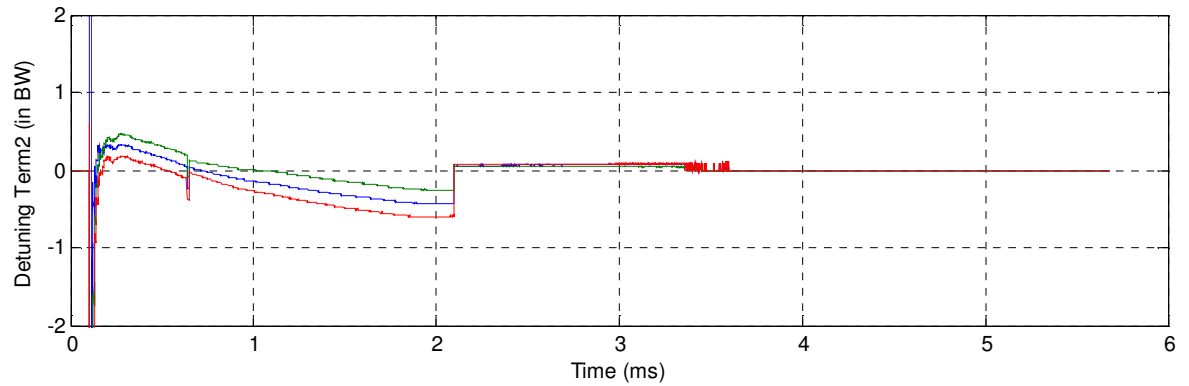
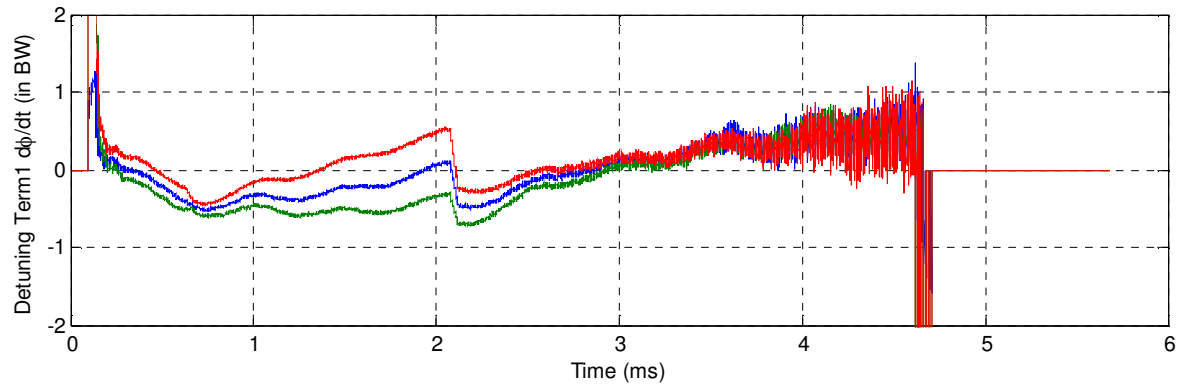
Klystron phase feed forward kicks in



Cavity was on tune

Preliminary results

- Calculated cavity detuning during the setting up process
- The cavity was deliberately detuned by known amount to verify the calibration and calculations



Conclusions and following actions

- Low power measurements:
 - Characterize cavity microphonics
 - Excitation by piezo to measure mechanical resonant modes of the cavity (f_{mech} and Q_{mech})
 - Excitation by piezo to get realistic model parameters for the compensation system (delay, tuning range etc.)
 - Find optimal piezo drive pulse shape (amplitude, delay, function, observe and mitigate resonant build-up of detuning from pulse-to-pulse)
 - Find optimal control algorithm to drive the piezo tuner

Conclusions and following actions

- High power measurements:
 - Measure and quantify dynamics of the cavity in a pulsed environment
 - Measure the mechanical mode damping times (2 Hz vs. 50 Hz operation)
 - Measure the klystron and cavity behaviour with full length, full power RF pulses
 - Quantify reproducibility of the klystron pulses
 - Quantify reproducibility of the cavity field pulses (feed-back vs. feed-forward compensation, how fast etc.)

SPL

LLRF simulations

Feasibility and constraints for operation with more than one cavity per klystron

Power overhead

Wolfgang Hofle

Acknowledgements and Participation:

S. Chel, G. Devanz, M. Desmons, O. Piquet (CEA Saclay)

M. Hernandez Flano, J. Lollierou, D. Valuch (FB section)

O. Brunner, E. Ciapala, F. Gerigk, J. Tuckmantel

This project has received funding from the European Community's Seventh Framework Programme (FP7/2007-2013) under the Grant Agreement n°212114

SPL parameters

SPL cavities and frequency: 704.4 MHz, cooling @ 2K He-II

Low energy part : $\beta=0.65$, 5-cell cavities, 6 cavities/cryostat,
60 cavities, $R/Q = 320 \Omega_{\text{linac}}$

1 klystron / cavity → likely baseline

High energy part: $\beta=1$, 5-cell cavities, 8 cavities/cryostat,
160 for 4 GeV (200 for 5 GeV) cavities, $R/Q = 525 \Omega_{\text{linac}}$

One 1.x MW klystron for 2 cavities (LPSPL)

One 1.x MW klystron for 1 cavity (HPSPL)

One ~5.5MW klystron per 4 cavities (previous)

SPL requirement: for $\beta=1 \rightarrow 25 \text{ MV/m}$

Stability: 0.5% and 0.5 degrees for V_{acc} during beam pulse

LPSPL:	4 GeV	2 Hz	1.2 ms beam pulse	20 mA beam current (DC)
HPSPL:	5 GeV	50 Hz	0.4 ms / 1.2 ms beam pulse	40 mA beam current (DC)

Cavity loaded $Q \sim 10^6$

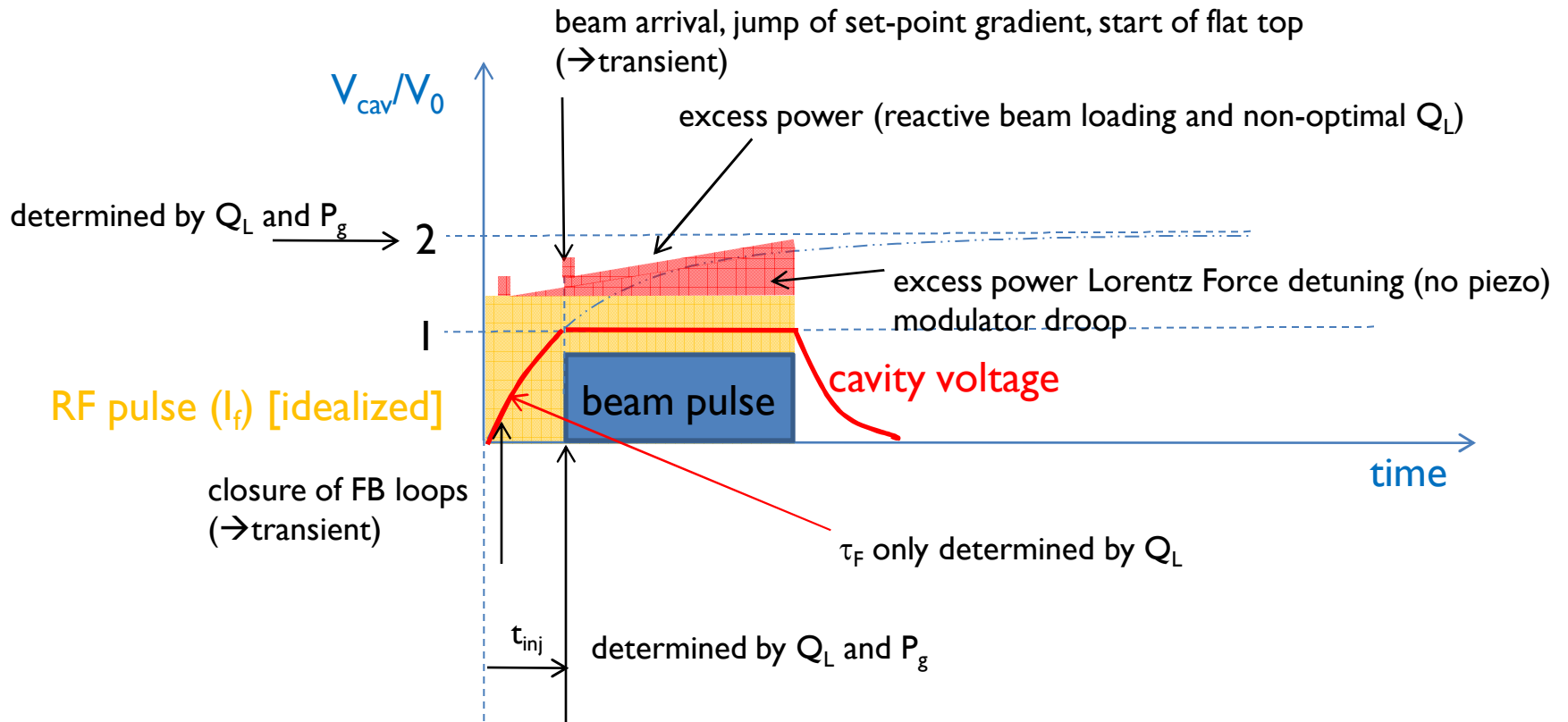
HPSPL: ppm change of beam pulse length ??

Fixed coupler position optimized for 40 mA operation, will give reflection @ 20 mA

$\phi_s = 15$ degrees

Principle of pulsed operation

SPL (with beam)



Parameters for 20 mA operation, with optimized coupling for zero reflected power during 40 mA beam pulse (1)

frequency: 704.4 MHz

accelerating gradient of $\beta=1$ cavities: 25 MV/m

length of cavity $L=\beta 5\lambda/2$: 1.06 m

cavity accelerating voltage for $\beta=1$: 26.5 MV

synchronous phase angle ϕ_s : 15 degrees

power delivered to beam $P_b = I_b \cdot V_{acc} \cdot \cos \phi_s = 512 \text{ kW}$

chosen (optimal value for 40 mA) $Q_{ext} \approx Q_L = 1.3064 \times 10^6$

reflected current in steady state with beam $I_r = \frac{V_{acc}}{(R/Q) Q_{ext}} - I_b \cos \phi_s = 19.3 \text{ mA}$

reflected power in steady state with beam $P_{refl} = \frac{1}{4} (R/Q) \cdot Q_{ext} \cdot |I_r|^2 = 64 \text{ kW}$

forward current in steady state with beam $I_f = \frac{V_{acc}}{(R/Q) Q_{ext}} + I_b \cos \phi_s = 58.0 \text{ mA}$

forward power in steady state $P_{fwd} = \frac{1}{4} (R/Q) \cdot Q_{ext} \cdot |I_f|^2 = 576 \text{ kW}$

Parameters for 20 mA operation, with optimized coupling for zero reflected power during 40 mA beam pulse (3)

2) 576 kW $V_{\infty} = V_{\text{fwd}} + V_{\text{refl}} = 2\sqrt{P_{\text{fwd}} Q_L (R/Q)} \approx 49.73 \text{ MV} \approx 1.5 \times V_0$

$$V(t) \approx \frac{3}{2} V_0 (1 - e^{-t/2\tau_F}) \rightarrow V_0 \quad \frac{1}{3} \approx e^{-t_{\text{inj}}/2\tau_F}$$

$$t_{\text{inj}} \approx 2\tau_{F,40\text{mA,opt}} \ln 3 \approx 1.099 \times \tau_{F,40\text{mA,opt}} \approx 0.648 \text{ ms}$$

compared to 40 mA opt. $t_{\text{inj}} = 2\tau_{F,40\text{mA,opt}} \ln 2 \approx 1.386 \times \tau_{F,40\text{mA,opt}} \approx 0.4092 \text{ ms}$

20 mA opt. $t_{\text{inj}} = 2\tau_{F,20\text{mA,opt}} \ln 2 \approx 1.386 \times \tau_{F,20\text{mA,opt}} \approx 0.8184 \text{ ms}$

$$Q_{\text{ext}} \approx Q_L = 1.3064 \times 10^6 \left\{ \begin{array}{ll} t_{\text{inj}} = 0.648 \text{ ms} & 0.576 \text{ MW, 2 cavities} \rightarrow 1.152 \text{ MW} \\ t_{\text{inj}} = 0.4092 \text{ ms} & 1.024 \text{ MW, 1 cavity} \rightarrow 1.024 \text{ MW} \end{array} \right.$$

12.5 % more power required for two cavities / klystron due to non optimal Q_{ext}

The maximum frequency range in which a rectangular wave guide supports the propagation of only one mode is one octave

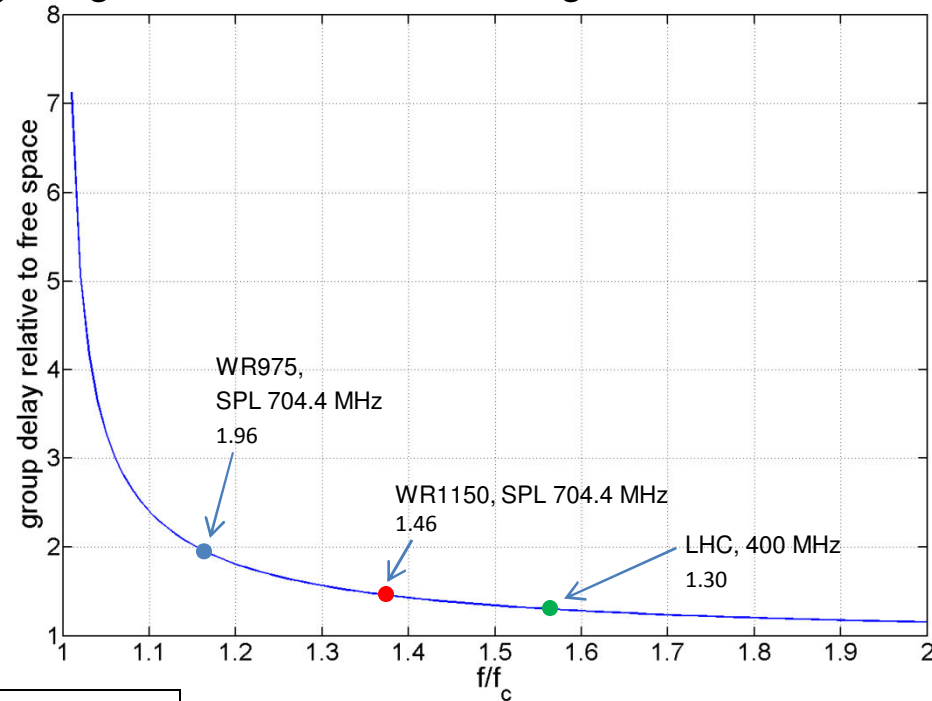
To obtain this maximum frequency range the width of the wave guide has to be at least a factor 2 of its height

The propagation constant is

$$\beta(\omega) = \frac{2\pi \cdot f}{c} \sqrt{1 - \left(\frac{f_c}{f}\right)^2}$$

The group delay is

$$\tau_g = \frac{L/c}{\sqrt{1 - \left(\frac{f_c}{f}\right)^2}}$$



	WR-975	WR-1150	LHC (WR-2300)
cut-off in MHz	605	513	257
group delay (rel to free space)	1.96	1.46	1.3
group delay (rel to WR-975)	1	0.74	0.66
rel cross section	1	1.18	2.36
cross section for 200 waveguides (full height, in m**2), net	6.16	7.27	15.54

← multiply by a factor 3-5 for required space

Group delay budget (tentative)

klystron:	250 ns ?
80 m waveguides (WR-1150)	360 ns (WR-1150)
80 m cabling (0.9 velocity factor)	270 ns
driver amplifier	40 ns
waveguide components (circulator etc.)	40 ns ?
local cabling (LLRF to klystrons etc.)	50 ns
LLRF latency	250 ns ?

total: 1260 ns

part related to 80 m distance
(surface to underground) 630 ns (50 %)

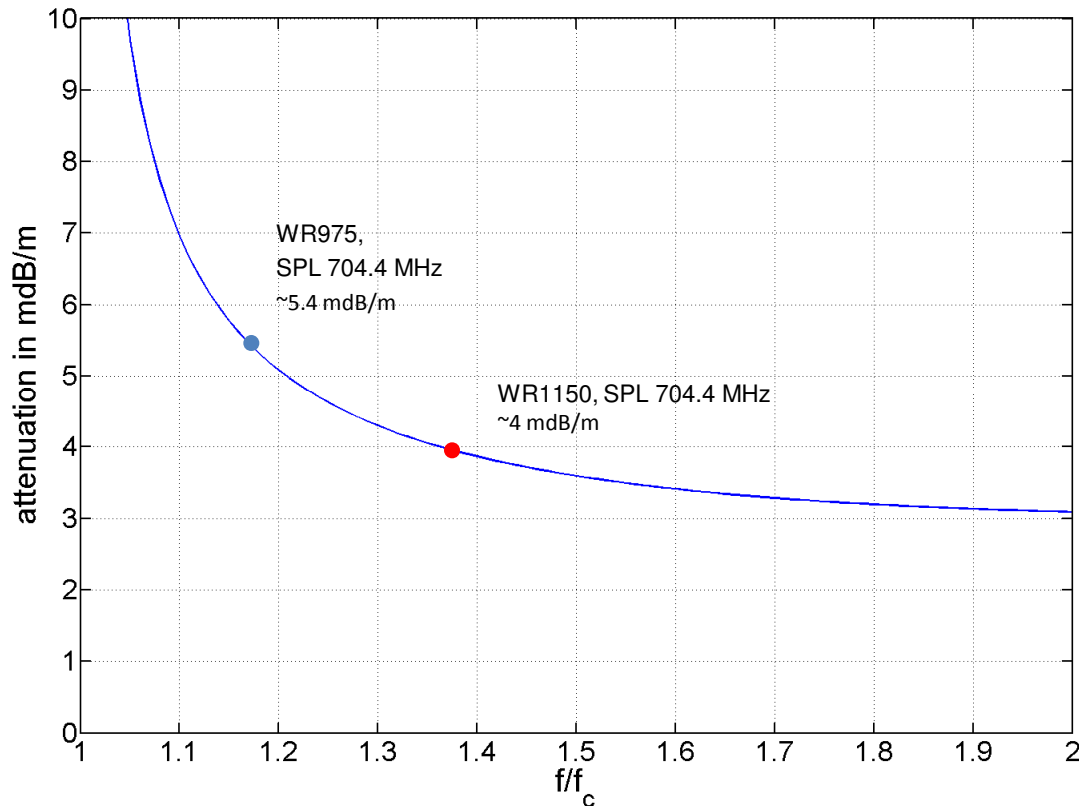
savings 60 m → 15 m
(2nd tunnel) 510 ns (40 %)

80 m seems ok (feedback does not need high bandwidth)

unknown, details to be studied: beam transients, chopping, HV ripple

Waveguide attenuation

From the attenuation point of view it is also better to stay away from the cut-off frequency, i.e. $f/f_c > 1.5$



Fundamental mode in full-height rectangular waveguide ($\text{Al } 37.7 \times 10^6 \text{ 1}/\Omega\text{m}$)
 AL alloys, Al Mg Si 0.5 \rightarrow 35 % to 45 % higher losses !

Power budget (very tentative)

power minimum two cavities / klystron
 reactive beam loading reserve
 detuning res. (Lorentz Force + micr.ph.)
 transients for loops
 variation in Q_L
 variation in cavity parameters
 beam current fluctuations
power at cavity input:

1152 kW
 20 kW
 20 kW ?
 50 kW
 15 kW ?
 15 kW ?
 40 kW ?
1302 kW ?

$$1532/1152 = 1.33$$

from klystron:
 end of life klystron reserve
 unusable (last 3%)
 waveguide losses
 circulator losses
 reserve for imperfect matching
 ripple and noise due to HV

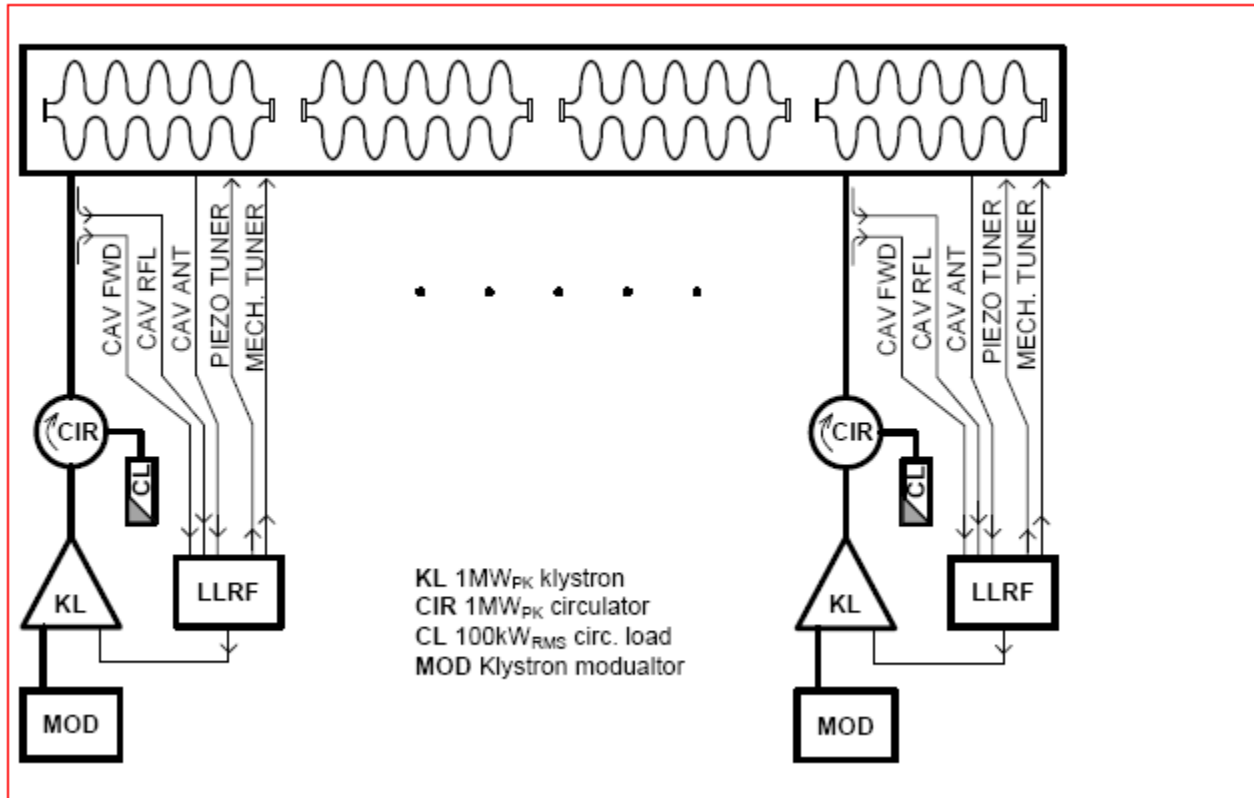
100%
 0%
 3%
 7% (more ?)
 3%
 0% ?
 3% ?

→ 85%

klystron peak (saturated) power: 1532 kW → no reserve for unforeseen items
 How much we need to stay away from klystron saturation – depends on klystron characteristics

Need simulations to better quantify these needs (see presentation by M. Hernandez)

Many possible Layouts, final for high energy part of HPSPL ?



1 klystron per cavity: individual control possible without RF vector modulator

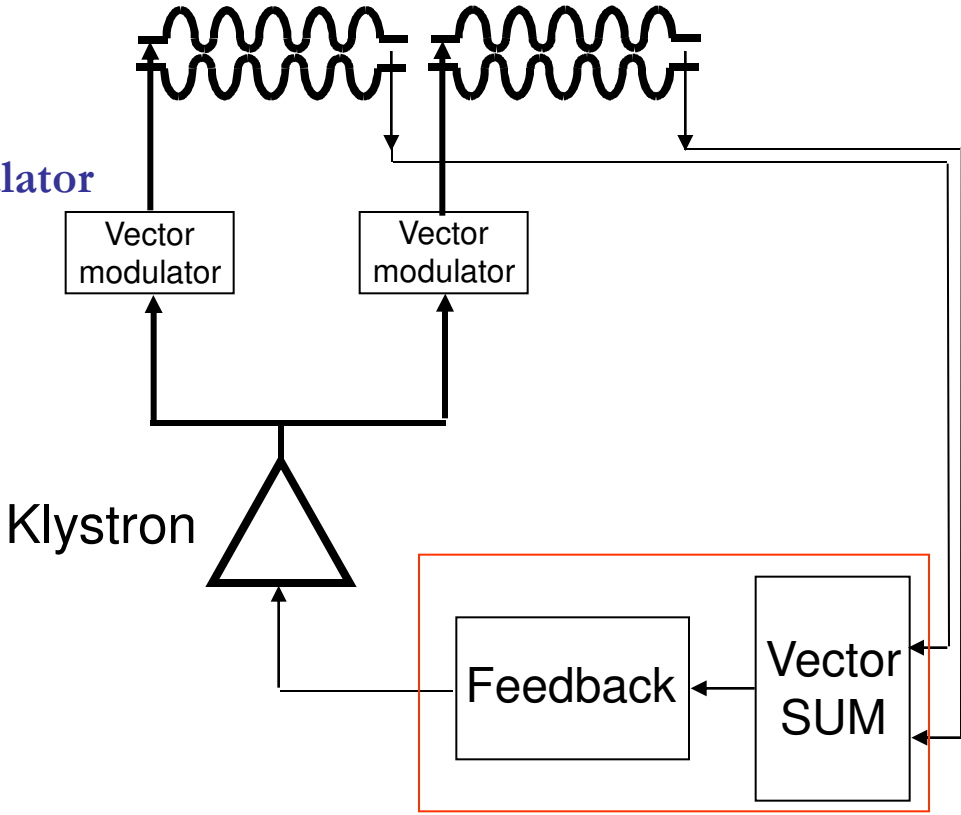
Disadvantage: Many klystrons required

Advantage: Easiest for control, considered adopted solution for low energy part

In this case and all following cases we assume individual Lorentz-force detuning compensation with a fixed pulse on the piezo or an adaptive feedforward (pulse-to-pulse)

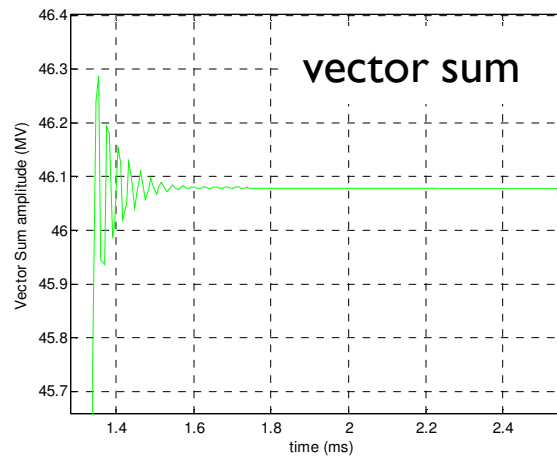
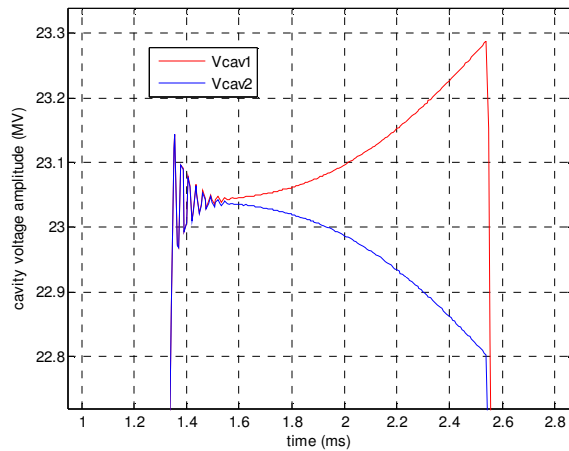
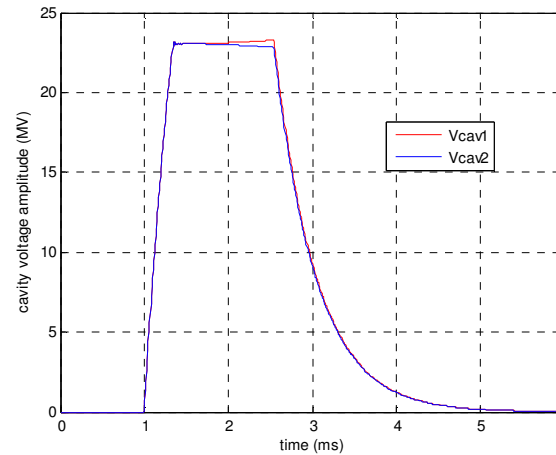
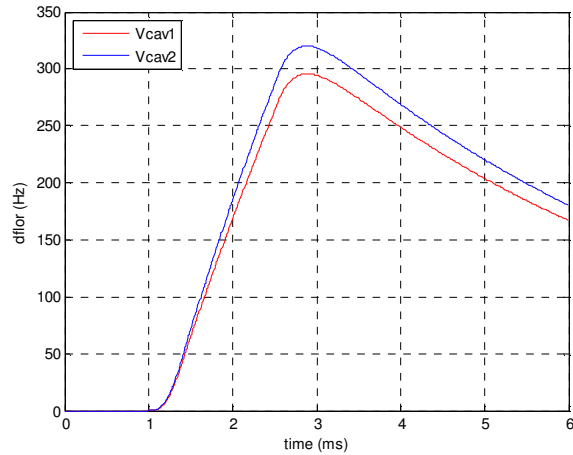
Many possible Layouts, initial for high energy part of LPSPL ?

optional
RF vector modulator



This case was analysed, see O. Piquet, CEA Saclay, simulation, LLRF09 workshop and **presentation by M. Hernandez Flano**

Two cavities per klystron high energy part of LPSPL



10% variation in
Lorentz Force detuning
 $K_{L,1} = -2.0 \text{ Hz}/(\text{MV}/\text{m})^2$
 $K_{L,2} = -2.2 \text{ Hz}/(\text{MV}/\text{m})^2$
PI FB controller
5 μs delay in FB loop
loop closed at start
of beam pulse

O. Piquet, CEA Saclay, simulation, LLRF09 workshop

- Matlab Simulink Modelling started
- Feedback and cavity simulations done
- Will be expended to include LFD, Mechanical resonances, waveguide elements.

- Baseline layout for Low/High B sections decided:
 - * 1.5 MW klystron for 2 cavities in High B LPSPL
 - * Single lower power source (IOT?) in Low B section
 - * Individual klystron per cavity in HPSPL High B (Integration must allow this..)
- No difficulties with long WR1150 waveguides (80m)
- Studies nevertheless need continue on stability/repeatability attainable in presence of microphonics, Lorenz detuning, detuned cavities, reflections due to RF distribution component imperfections etc.
- Power coupler experience from CEA, LAL & CERN is very valuable, synergy & common experience.
 - => Final designs to be studied at March Workshop
- Magnetron development work to be followed up
- Construction of test area in SM18 for RF power and cavity work
(Details to be elaborated shortly after the workshop)

- Need for adjustable coupler
- Positioning of coupler (Top / Bottom)
- Can we get a 'compact modulator' for HPSPL ?

Thanks to all the speakers
and to the participants for all the valuable feedback